# U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE 

 CLASSIFICATION ORDER 1905FEBRUARY 1, 2011
PROJECT E-7273

The following classification changes will be effected by this order:

|  | Class | $\underline{\text { Subclass }}$ | Art <br> Unit | Ex'r Search <br> Room |
| :--- | :--- | :--- | :--- | :--- |
| Abolished: | 359 | $483-502$ | $\underline{2872}$ | RND0000B15 |
| Established: | 359 | $483.01,484.01-484.09,484.1$, | 2872 | RND0000B15 |
|  |  | $485.01-485.07,486.01-486.03$, <br> $487.01-487.06,488.01,489.01-$ |  |  |
|  |  | $489.09,489.1,489.11-489.19$, |  |  |
|  |  | $489.2,490.01-490.03,491.01$, |  |  |
|  |  | $492.01,493.01,494.01$ |  |  |

The following classes are also impacted by this order:
40, 106, 250, 313, 343, 351, 353, 356, 360, 362, 365, 369, 385, 386, 398, 427, 428, 430
This order includes the following:
A. CLASSIFICATION MANUAL CHANGES
B. LISTING OF PRINCIPAL SOURCE OF ESTABLISHED AND DISPOSITION OF ABOLISHED SUBCLASSES
C. CHANGES TO THE USPC-TO- IPC CONCORDANCE
D. DEFINITION CHANGES AND NEW OR ADDITIONAL DEFINITIONS

# CLASSIFICATION ORDER 1905 

FEBRUARY 1, 2011

PROJECT E-7273

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| 1 | HOLOGRAPHIC SYSTEM OR ELEMENT | 197.1 | .Using a periodically moving |
| :---: | :---: | :---: | :---: |
| 2 | .Authentication |  | element |
| 3 | .Having particular recording medium | 198.1 | ..With particular mount or driver for element |
| 4 | . Recyclable | 199.1 | ...Oscillating driver |
| 5 | .Magnetic material | 199.2 | ....Electrostatically driven |
| 6 | . Sandwich having photoconductor | 199.3 | ....Electromagnetically driven |
| 7 | ...Crystalline material | 199.4 | ....Electromechanically driven |
| 8 | ..Having nonplanar recording medium surface | 200.1 | ...Bearing or shaft for rotary driver |
| 9 | .For synthetically generating a hologram | 200.2 | ....Specific shaft material or structure (e.g., ceramic ring) |
| 10 | .Using modulated or plural reference beams | $\begin{aligned} & 200.3 \\ & 200.4 \end{aligned}$ | .....Grooved shaft <br> ....Fluid pressure bearing |
| 11 | ..Spatial, phase or amplitude modulation | $\begin{aligned} & 200.5 \\ & 200.6 \end{aligned}$ | .....Dynamic fluid bearing <br> ...Electrostatic driver |
| 12 | . Copying by holographic means | 200.7 | ...Electromagnetic driver |
| 13 | .Head up display | 200.8 | Electromechanical driver |
| 14 | . Holograph on curved substrate | 201.1 | ..With multiple scanning elements |
| 15 | .Using a hologram as an optical element |  | (e.g., plural lenses, lens and prism, etc.) |
| 16 | ..With aberration correction | 201.2 | ...Reflective element (e.g., |
| 17 | . Scanner |  | mirror, reflector, etc.) |
| 18 | .Flat rotating disk | 202.1 | X-Y scanners |
| 19 | Lens | 203.1 | ...Having a common axis or |
| 20 | ...Multiple point hologram (e.g., fly-eye lens, etc.) | 204.1 | rotation <br> ..Utilizing multiple light beams |
| 21 | .Having defined page composer | 204.2 | ...Including modulated light beam |
| 22 | .For producing or reconstructing images from multiple holograms (e.g., color, etc.) | $\begin{aligned} & 204.3 \\ & 204.4 \end{aligned}$ | ...Including polarized light beam <br> ...Having multiple light beams with visible wavelengths |
| 23 | . .Holographic stereogram | 204.5 | ...With diffraction grating |
| 24 | ..Superimposed holograms only | 205.1 | ..Post scanning optical element |
| 25 | . Discrete hologram only | 206.1 | ...High distortion lens (e.g., f- |
| 26 | ...Sequential frames on moving film | 207.1 | Theta lens) <br> ...Anamorphic elements |
| 27 | .Having particular laser source | 207.2 | ....Having an aspheric surface |
| 28 | .Having multiple object beam or diffuse object illumination | $\begin{aligned} & 207.3 \\ & 207.4 \end{aligned}$ | .....Multiple aspheric surfaces <br> ......Multiple symmetrical |
| 29 | .Fourier transform holography |  | aspheric surfaces |
| 30 | .Having optical element between object and recording medium | 207.5 | ......Multiple nonsymmetrical aspheric surfaces |
| 31 | . .Focused image holography | 207.6 | ...Cylindrical or toric lens |
| 32 | .For reconstructing image | 207.7 | ...With diffraction portion or |
| 33 | ..Real image |  | element |
| 34 | .With optical waveguide | 207.8 | ...With reflecting prism |
| 35 | .Hardware for producing a hologram | 207.9 207.11 | ...Polarized beam <br> ...Thermal compensation |
| 107 | OPTICAL COMPUTING WITHOUT | 208.1 | . Concave reflector |
|  | DIFFRACTION | 208.2 | ....Aspheric reflector |
| 108 | .Logic gate | 209.1 | . Transmissive type moving |
| 196.1 | deflection using a moving element |  | element |
|  |  | 210.1 | . Moving lens |


| 210.2 | .Rotational Lens | 230 |
| :---: | :---: | :---: |
| 211.1 | ...Moving prism | 231 |
| 211.2 | ....Rotating prism | 232 |
| 211.3 | .....Multiple prisms | 233 |
| 211.4 | ....With angled axis of rotation |  |
| 211.5 | ....Rotating element | 234 |
| 211.6 | ....With diffraction grating |  |
| 212.1 | ..reflective type moving element | 235 |
| 212.2 | ...Rotating reflective element |  |
| 213.1 | ...Oscillating reflective element | 236 |
| 214.1 | ....Single plane mirror |  |
| 215.1 | .....with imaging lens | 237 |
| 216.1 | . .Multifaceted rotating element | 238 |
| 218.1 | ....Having six, seven, or eight facets |  |
| 219.1 | .Having five or fewer facets | 239 |
| 219.2 | . Inclined reflective elements |  |
| 217.1 | ....With facet plane | 240 |
|  | substantially parallel to rotating axis plane | 241 |
| 217.2 | .With beam modulation | 242 |
| 217.3 | ....Having vibration absorbing means | 243 |
| 217.4 | .With diffractive element | 245 |
| 220.1 | ...Rotation axis traversely oriented relative to reflective element | 246 247 |
| 221.1 | ...Having planar rotating reflector with co-planar axis of rotation | 248 249 |
| 221.2 | .With particular mount or drive for element | 250 251 |
| 221.3 | ..Bearing or shaft for rotary driver |  |
| 221.4 | ...Specific shaft material or structure (e.g., ceramic ring) | 252 |
| 222.1 | .By frustrated total internal reflection | 253 |
| 223.1 | . By moving a reflective element | 254 |
| 224.1 | ..Reflective element moved by deformable support |  |
| 224.2 | ...Modulated light beam |  |
| 225.1 | ..Pivotally or moving in circular arc | $\begin{aligned} & 255 \\ & 256 \end{aligned}$ |
| 226.1 | . .Rotating | 257 |
| 226.2 | . Pivotal or rotational element | 258 |
| 226.3 | .Fluid filled medium | 259 |
| 227 | LIGHt Control by opague element | 260 |
|  | OR MEDIUM MOVABLE IN OR THROUGH LIGHT PATH | 261 |
| 228 | .Fluid | 262 |
| 229 | .With glare or flicker | 263 |
|  | elimination | 264 |

.Electro-mechanical
..String or ribbon type
.Slit type
.With relative motion of two apertured elements
.With rotating or pivoting element (e.g., scanning discs)
. Continuously rotating apertured element
..Element rotates about axis perpendicular to light path

## OPTICAL MODULATOR

.Light wave temporal modulation (e.g., frequency, amplitude, etc.)
..Modulator output feedback to modulator
..Changing bulk optical parameter
...By actinic radiation (e.g., photochromic)
....Display device
....Bistable device
....Opto-optical device
...Electro-optic
....Modulation of polarized light via modulating input signal
.....Using reflective or cavity structure
. . . . . .Semiconductor
.....Compensation technique
.....Using plural mediums
.....With particular direction of the field in relation to the medium, beam direction or polarization
.....With particular medium or state of the medium
...... Liquid medium
.....With particular electrode structure or arrangement, or medium mounting structure or arrangement
.....With particular field
.....With birefringent element
.....Pockel`s cell
......Kerr cell
....Plural modulation cells
....Etalon structure
....Multiple reflections within cell
....Excitation by electron beam
....By reflection
....Pulse modulation
....Electrochromic
.....Particular nonplanar electrode arrangement
.....Reflection-type (e.g., display device)
...... Complementary device
......Particular counter electrode
......Particular electrolyte layer
.......Particular planar electrode pattern
.......Liquid cell
......Particular electrochromic
layer structure
......Diverse layer
.....Transmission-type (e.g., windows)
....Amplitude modulation
.....Within display element
.....Frequency modulation
....Phase modulation
. . .Magneto-optic
.....Modulation of polarized light via modulating input signal
.....Using layered structure or plural mediums
.....With particular direction of the field in relation to the medium, beam direction or polarization
....Amplitude modulation
...Acousto-optic
....Amplitude modulation
....Frequency modulation
...Thermo-optic
....Amplitude modulation
.. By changing physical characteristics (e.g., shape, size or contours) of an optical element
...Shape or contour of light control surface altered
....Light control surface forms image on projected light beam
.....Electron beam causes surface alteration
....Using photoconductive layer
....Having multiple electrodes
...Changing position or orientation of suspended particles
...Light control surface formed or destroyed
.Light wave directional modulation (e.g., deflection or scanning is representative of the modulating signal)
..Opto-optical device
..Phase conjugate
. Acting on polarized light
...Using reflecting or cavity structure
...Using more than one polarization (e.g., digital)
...Using single polarization
. Acousto-optic
...Correlation or convolution
...Utilizing optical feedback
...Filter
...Acting on polychromatic light
...Plural cell array
...Plural transducers on single cell
...Single transducer generating composite plural frequency acoustic wave
...Particular cell shape
...Particular cell orientation
..Electro-optic
...Plural modulation cells
...Multiple reflections within cell
...By reflection
...Focusing
...Switching
.Having particular chemical composition or structure
..Electro-optic crystal material
...PLZT material
..Magneto-optic crystal material
OPTICAL DEMODULATOR
OPTICAL FREQUENCY CONVERTER
. Raman type
.Harmonic generator
. .Third harmonic
. Parametric oscillator
. Optical laser acoustic delay line type
. Dielectric optical waveguide type

## OPTICAL AMPLIFIER

. Raman or Brillouin process
.Free electron
. Bistable
.Correction of deleterious effects

\begin{tabular}{|c|c|c|}
\hline 337.1 \& ..Spectral gain flattening or equalization \& $$
\begin{aligned}
& 357 \\
& 358
\end{aligned}
$$ <br>
\hline 337.11 \& . . . Feedback \& 359 <br>
\hline 337.12 \& ....Using number of signals \& <br>
\hline 337.13 \& ....Adjusting input signal power \& 360 <br>
\hline 337.2 \& ..Filtering (e.g., noise) \& 361 <br>
\hline 337.21 \& . . . Grating \& <br>
\hline 337.22 \& ...Interferometer or interference \& 362 <br>
\hline 337.3 \& ..Additional dopant or host composition \& 363
364 <br>
\hline 337.4 \& ..Complementary, adjusting stages \& <br>
\hline 337.5 \& . Dispersion compensation \& 365 <br>
\hline 338 \& ..Using phase conjugation \& 366 <br>
\hline 339 \& ..Using saturable or spatial filter \& 367
368 <br>
\hline 340 \& .Mode locked \& 369 <br>
\hline 341.1 \& . Optical fiber \& 370 <br>
\hline 341.2 \& ..Bi-directional \& 371 <br>
\hline 341.3 \& . . Pumping \& 372 <br>
\hline 341.31 \& ...Operating frequency \& 373 <br>
\hline 341.32 \& ...Radiation routing \& 374 <br>
\hline 341.33 \& ...With multiple systems \& 375 <br>
\hline 341.4 \& . .Feedback \& 376 <br>
\hline 341.41 \& ...Automatic Gain Control (AGC) \& 377 <br>
\hline 341.42 \& ...Automatic Level Control (ALC) \& <br>
\hline 341.43 \& ...Surge protection \& 378 <br>
\hline 341.44 \& ...Fault detection \& 379 <br>
\hline 341.5 \& ..Composition (e.g., Tm, Tb, Eu, Ho, Dy, Nd) \& 380 <br>
\hline 342 \& . Particular active medium (e.g., crystal, plasma, fluid, etc.) \& 381 <br>
\hline 343 \& ..Glass (amorphous) \& 382 <br>
\hline 344 \& . .Semiconductor \& <br>
\hline 345 \& .Particular pumping type (e.g., electrical, optical, nuclear, magnetic, etc.) \& $$
\begin{aligned}
& 383 \\
& 384 \\
& 385
\end{aligned}
$$ <br>
\hline 346 \& . Particular resonator cavity (e.g., scanning, confocal or folded mirrors, etc.) \& $$
\begin{aligned}
& 386 \\
& 387
\end{aligned}
$$ <br>
\hline 347 \& .Multiple pass \& 388 <br>
\hline 348 \& . .Regenerative \& 389 <br>
\hline 349 \& . Beam combination or separation \& <br>
\hline 350 \& HAVING SIGNIFICANT INFRARED OR ULTRAVIOLET PROPERTY \& 390 <br>
\hline 351 \& .Having folded optical path \& 391 <br>
\hline 352 \& .Having polarizing element \& 392 <br>
\hline 353 \& .Including alternative optical path or optical element (e.g., day-night, hi-low magnification) \& 393

394
395 <br>
\hline 354 \& .Including continuously variable magnification or focal length (zoom lens, adjustable lens) \& 396
397
398 <br>
\hline 355
356 \& .Lens, lens system or component
..Infrared lens \& 399 <br>
\hline
\end{tabular}

...Having four or more components .Fluid filter or fluid mirror .Multilayer filter or multilayer reflector
..Having metal layer
.Having ultraviolet absorbing or shielding property
COMPOUND LENS SYSTEM
.With image recorder
.With curved reflective imaging element
..Two or more in a series
...Concave, convex combination
.Right angle inspector
.Microscope
..With viewed screen
..Interference
...Using polarized light
..With plural optical axes
...Side-by-side fields
...Plural oculars
....Binocular
.....Stereoscopic
.......With single or parallel objectives
.......For viewing stereo pairs
..Spacing of optical elements axially adjustable
...Variable magnification
..Imaging elements movable in and out of optical axis
..Entire microscope adjustable along optical axis
...Focus adjustment
..With rotatable adjustment
..Illuminator
...Using polarized light
...With annular lighting structure
...With optical switching means
...With illumination and viewing paths coaxial at the image field
...With illuminator support
..Stage or slide carrier
...Adjustable along optical axis
...With plural transverse movements
...With turntable
...With temperature control
..Transparent slide
...Reference lines or grids
...Specimen cavity or chamber
.Telescope

| 400 | ..With viewed screen | 442 |
| :---: | :---: | :---: |
| 401 | ..With image anti-rotation | 443 |
| 402 | . . Periscope | 444 |
| 403 | ...With plural optical axes | 445 |
| 404 | ..Binocular | 446 |
| 405 | ...With mechanical adjustment | 447 |
| 406 | ....Extensible structure |  |
| 407 | . . Binocular | 448 |
| 408 | ...Foldable or collapsible |  |
| 409 | ...Body supported or with handle | 449 |
| 410 | ...With focusing means |  |
| 411 | ....With adjustable interocular distance | $\begin{aligned} & 450 \\ & 451 \end{aligned}$ |
| 412 | ...With adjustable interocular distance | $\begin{aligned} & 452 \\ & 453 \end{aligned}$ |
| 413 | ....Oculars swing about central axis | 454 |
| 414 | .....Spacing of optical elements axially adjustable | $\begin{aligned} & 455 \\ & 456 \end{aligned}$ |
| 415 | ....Oculars rotate about separate axes | $\begin{aligned} & 457 \\ & 458 \end{aligned}$ |
| 416 | .....Spacing of optical elements axially adjustable | 459 |
| 417 | ....Spacing of optical elements axially adjustable | 460 |
| 418 | ...Spacing of optical elements axially adjustable | 461 462 |
| 419 | ..With plural optical axes | 463 |
| 420 | ...Plural magnification in same viewing field | 464 |
| 421 | ..Selectable magnification |  |
| 422 | . Variable magnification |  |
| 423 | . .With relay | 465 |
| 424 | . With reticle | 466 |
| 425 | ..Focusing or relatively sliding barrels | $\begin{aligned} & 467 \\ & 468 \end{aligned}$ |
| 426 | ...Internal focusing |  |
| 427 | ...With reticle | 469 |
| 428 | . .With reticle | 470 |
| 429 | ..With line of sight adjustment |  |
| 430 | ...Equatorial mount |  |
| 431 | ..With prism or U-shaped optical path | $\begin{aligned} & 471 \\ & 472 \end{aligned}$ |
| 432 | .Variable magnification |  |
| 433 | .With tilted lens or tilted image plane | 473 |
| 434 | .With relay |  |
| 435 | ..Repetitious lens structure | 474 |
| 436 | SCALE OR INDICIA READING | 475 |
| 437 | . Polarizer | 476 |
| 438 | . Prism |  |
| 439 | . Mirror | 477 |
| 440 | . Lens |  |
| 441 | . .Movable or adjustable | 478 |

401
402
403
404
405
406
407
..With plural optical axes
...With reticle barrels
...Internal focusing
...With reticle
. With reticle
..With line of sight adjustment
...Equatorial mount
. With prism or U-shaped optical path
.Variable magnification
.With tilted lens or tilted image plane
.With relay
..Repetitious lens structure
SCALE OR INDICIA READING
.Polarizer
.Prism
.Lens
. Movable or adjustable
...Along scale or indicia

## PROJECTION SCREEN

.With sound producer
. Acoustical
.Moving during projection
.Tracing (e.g., camera lucida, etc.)
.With lens (e.g., camera obscura, etc.)
. With reflector or additional screen
.Border, mask, shade, or curtain
. Curved
.Embedded particles
..Rear projection screen
.Unitary sheet comprising plural refracting areas
..Lenticular
...Rear projection screen
....With Fresnel lens
...Stereoscopic imaging or three dimensional imaging
.Unitary sheet comprising plural reflecting areas
.Rear projection screen
. Roll up screen

## STEREOSCOPIC

.Having record with lenticular surface
.With right and left channel discriminator (e.g., polarized or colored light)
..Using polarized light
.Stereo-viewers
..View changers
...Picture moves linearly past viewing aperture
....Using film strips
..Compensates for camera position (e.g., plotting or mapping type)
..Reflected line of sight
...Pictures offset, transposed or have respective right or left sides adjacent
. Ocular spacing or angle between ocular axes adjustable
. Collapsible
..Having illumination
. Ocular to picture distance adjustable
..Supporting, mounting, enclosing or light shielding structure

## relief illusion

.Reflected line of sight

| 480 | BINOCULAR DEVICES |
| :---: | :---: |
| 481 | . Binocular loupe type |
| 482 | . Reflected line of sight |
| 483.01 | POLARIZATION WITHOUT MODULATION |
| 484.01 | .Polarization using a time invariant electric, magnetic, or electromagnetic field (e.g. electro-optical, magnetooptical) |
| 484.02 | ..Faraday effect |
| 484.03 | ...Isolator |
| 484.04 | . With reflector |
| 484.05 | ...Circulator |
| 484.06 | ...Optical switch |
| 484.07 | . Interleaver |
| 484.08 | Attenuator |
| 484.09 | . Interference or comb filter |
| 484.1 | ...With particular Faraday effect material |
| 485.01 | .Polarization by reflection or refraction |
| 485.02 | ..Brewster angle polarizer (reflective or transmissive) |
| 485.03 | ..Multilayer polarizer |
| 485.04 | ...Pile-of-plates polarizer |
| 485.05 | ..Wire grid polarizer |
| 485.06 | . Prism |
| 485.07 | . Mirror |
| 486.01 | .Polarization (direction or magnitude) variation over surface of the medium |
| 486.02 | ..Linear variation |
| 486.03 | . Radial variation |
| 487.01 | . Polarizarion by dichroism |
| 487.02 | ..With stain or dye |
| 487.03 | ..Wire grid polarizer |
| 487.04 | . .Wavelength-selective beamsplitter |
| 487.05 | ..Having plural elements |
| 487.06 | . Oriented particles |
| 488.01 | .Glare prevention by discriminating against polarized light |
| 489.01 | . Polarization by birefringence |
| 489.02 | . With compensation techniques |
| 489.03 | ...Intrinsic birefringence or photoelastic (stress) effect |
| 489.04 | . . .Temperature |
| 489.05 | ...Path length |
| 489.06 | ..Form birefringent element |
| 489.07 | ..Waveplate or retarder |
| 489.08 | .. Beam deflector or splitter |
| 489.09 | . . . Prism |
| 489.1 | . Adjustible element(s) |

489.11
489.12
489.13
489.14
489.15
489.16
489.17
489.18
489.19
489.2
490.01
490.02
490.03
491.01
492.01
493.01
494.0

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525
526
527
...Film or layer
....Uniaxial
....Biaxial
. . Lens
..Plural birefringent elements
...Three or more birefringent elements
...In parallel
...With lenses
...Frequency filter or interference effects
..Mounting structure
.By relatively adjustable superimposed or in series polarizers
..Rotating elements
..Translating or sliding elements
.With color filter
. Polarization by optical activity
.Polarization by scattering
. Depolarization
EXTENDED SPACING STRUCTURE FOR OPTICAL ELEMENTS
.Wide angle (e.g., door peep)
.With screen or reticle in real image plane
.Extension of tubular element adjustable
PROTECTION FROM MOISTURE OR FOREIGN PARTICLE
.Optical element rotates
.Fluid directed across optical element
.Microscope drape
. Cap or cover
.Humidity or temperature control
.Sealing
..Mirror, prism or signal reflector

## SIGNAL REFLECTOR

.Body carried
..Worn by hand or wrist
..Permanently fixed to clothing
..Worn over clothing
.Moving
..Pedal mounted
. .Rotating
...Spoke mounted
...Tire, wheel, valve stem, hub cap, or axle mounted
...Wind driven
..Vibration
.For a signal source remote from observer

528


.Unitary light transmitting 628
member comprising plural
reflecting or refracting
elements
..Plural members in series
..Elements on two sides of member
..With internal reflections
.Slats or strips
.With reflection
..Internal reflection in single
optical element
DIFFUSING OF INCIDENT LIGHT
barrel end eye guard (e.g.,
SHIELD OR CUSHION, ETC.)
GLARE OR UNWANTED LIGHT REDUCTION
.With mirror (e.g., mirror with
glare screen, etc.)
. Anti-glare mirror
...Adjustable
....Plural reflecting surfaces
..... Prismoidal
..... Reversible
....Translucent or other
semitransmitting panel
selectively positioned in
front of mirror
.Display window
. With blind for nonviewing eye
. Barrel end or lens mount shade
. Collapsible or foldable
.Directional or angular
discrimination
.With absorption means
LIGHT DISPERSION
KALEIDOSCOPE
.Including particles loosely
housed for agitation
SINGLE CHANNEL SIMULTANEOUSLY TO
OR FROM PLURAL CHANNELS (E.G.,
LIGHT DIVIDING, COMBINING, OR652
PLURAL IMAGE FORMING, ETC.) 653
.By surface composed of
lenticular elements
654
655
..Having particular composition
..Plural lenticular plates
656
...Serially disposed along optic 657
axis
....Cylindrical lenslets 659
658
.....Having crossed axes
660
..Focusing or defocusing by 661
noncurved surfaces (e.g.,
prismatic, etc.)
662
..Particular focusing or
defocusing characteristic
663
. .Reflective
..Noncircular cross section
.By partial reflection at beam splitting or combining surface
..Superimposing visual information on observer`s field of view (e.g., head-up arrangement, etc.)
...Including curved reflector
...Rotatable heads-up device or combiner
...With additional reflector (e.g., serial reflections, etc.)
..Wavelength selective (e.g., dichroic mirror, etc.)
..Drawing or plotting aid
..Including full reflection and transmission of a beam at different portions of a beam divider
..With path length or aberration correcting element
..With partial reflection at a surface of a prism
.By refraction at beam splitting or combining surface
..Including prismatic element
COLLIMATING OF LIGHT beAM
LENS
.Eyepiece
..Having four components
. Having three components
..Having two components
. Having one component
.With field curvature shaping
..Projection type
...Having four components
...Having less than four components
.With graded refractive index
..Having an axial gradient
..Having a radial gradient
...In a variable media (e.g., gas, elastomer, etc.)
.Microscope objective
..Having seven components
..Having six components
..Having five components
..Having four components
..Having less than four components
.High distortion lens (e.g., f0, etc.)
.Telecentric system
.Spherical

| 665 | .Fluid | 708 | . Including a nonspherical surface |
| :---: | :---: | :---: | :---: |
| 666 | ..With variable magnification | 709 | . Conical |
| 667 | ..With gas | 710 | . Cylindrical |
| 668 | . Anamorphic | 711 | . .Toroidal |
| 669 | ..With prism anamorphoser | 712 | . . Paraboloidal |
| 670 | ..Variable magnification anamorphoser | 713 | ..Having six components <br> ..Having five components |
| 671 | ..Having four or more components | 715 | ..Having four components |
| 672 | .Selective magnification by exchanging or adding a lens component | $\begin{aligned} & 716 \\ & 717 \\ & 718 \end{aligned}$ | ..Having three components <br> ..Having two components <br> ..Having one component |
| 673 | ..To the front of a basic lens | 719 | ...Objective for laser (e.g. |
| 674 | ..To the middle of a basic lens |  | optical disc, etc.) |
| 675 | ..To the rear of a basic lens | 720 | .Asymmetric (e.g., prismatic or |
| 676 | .With variable magnification (e.g., zoom type) | 721 | eccentric, etc.) <br> .Plural focal length |
| 677 | . Optically compensated | 722 | .Selective wavelength |
| 678 | ..Prism lens type |  | transmitting or blocking |
| 679 | ..With fixed conjugates | 723 | ..With separate filter |
| 680 | . .Reverse telephoto | 724 | . Annular zonal correcting |
| 681 | ...Having eight or nine components | 725 726 | . Panoramic <br> .With reflecting element |
| 682 | ...Having seven or less components | 727 | ..Including concave or convex reflecting surface |
| 683 | . With mechanical compensation | 728 | ...With aspheric surface (e.g., |
| 684 | ...Other than first group moves for focusing (internal focus type) | 729 | Schmidt lens, etc.) <br> ....With concave and convex reflectors in series |
| 685 | ...Nonlinear variator/compensator movements | $\begin{aligned} & 730 \\ & 731 \end{aligned}$ | ...Reflectors in series <br> ....With concave and convex |
| 686 | ...Four groups |  | reflectors in series |
| 687 | ....+ - + + Arrangement | 732 | ..For producing a double pass |
| 688 | ....+ - - + Arrangement | 733 | ..Multiple component lenses |
| 689 | ...Three groups | 734 | ...Four components |
| 690 | ....+ - + Arrangement | 735 | ...Three components |
| 691 | . . Two groups | 736 | ...Two components |
| 692 | ...+ - Arrangement | 737 | . With diverse refracting element |
| 693 | ...With macro-type focusing | 738 | .With light limiting or |
| 694 | ..Adjusting mechanism |  | controlling means |
| 695 | ...Three or more movable lens groups | $\begin{aligned} & 739 \\ & 740 \end{aligned}$ | . .Diaphragm <br> ...Between lens components |
| 696 | Motor driven | 741 | .With multipart element |
| 697 | ....Condition responsive | 742 | ..Echelon (e.g., Fresnel lens, |
| 698 | .....Auto focusing |  | etc.) |
| 699 | ..Having cam device | 743 | ...Having curvilinear lens |
| 700 | ....Cam groove type | 744 | .Afocal (e.g., Galilean |
| 701 | ....Cam ring type or zoom ring type | 745 | telescopes, etc.) .Telephoto |
| 702 | ...With adjustment lock | 746 | ..With five components |
| 703 | ...With specified mount | 747 | ..With four components |
| 704 | ....Having detail of barrel | 748 | ..With less than four components |
| 705 | ...With macro type focusing | 749 | . Reverse telephoto |
| 706 | ....With specific ring means | 750 | ..With eight components |
| 707 | . Diffusing | 751 | . With seven components |


| 752 | . With six components | 799 |
| :---: | :---: | :---: |
| 753 | ..With five or less components |  |
| 754 | .Multiple component lenses | 800 |
| 755 | ..Seven components | 801 |
| 756 | ..Six components | 802 |
| 757 | ...First component positive | 803 |
| 758 | ....+ - + + - + Arrangement | 804 |
| 759 | ....First two components positive | 805 |
| 760 | .....+ + - - + + Arrangement | 806 |
| 761 | ...First component negative |  |
| 762 | ....First two components negative |  |
| 763 | ..Five components | 807 |
| 764 | ...First component positive | 808 |
| 765 | ....+ - - + + Arrangement | 809 |
| 766 | ....+ - + - + Arrangement |  |
| 767 | ....First two components positive | 810 |
| 768 | .....+ + - - + Arrangement | 811 |
| 769 | .....+ + - + + Arrangement | 812 |
| 770 | ...First component negative | 813 |
| 771 | ..Four components | 814 |
| 772 | ...First component positive | 815 |
| 773 | ....+ - + - Arrangement |  |
| 774 | ....+ - + + Arrangement | 816 |
| 775 | ....+ - - + Arrangement | 817 |
| 776 | .....With multiple element component | $\begin{aligned} & 818 \\ & 819 \end{aligned}$ |
| 777 | ......Infinite radius | 820 |
| 778 | ......Having a biconvex single element component | 821 |
| 779 | ....+ + - + Arrangement |  |
| 780 | ....+ + + - Arrangement |  |
| 781 | ...First component negative | 822 |
| 782 | ....- + + - Arrangement | 823 |
| 783 | ....- + + + Arrangement |  |
| 784 | ..Three components | 824 |
| 785 | ...+ - + Arrangement |  |
| 786 | ....With multiple element first component | $\begin{aligned} & 825 \\ & 826 \end{aligned}$ |
| 787 | ....With multiple element second component | 827 |
| 788 | ....With multiple element third component | 828 829 |
| 789 | ....With first component biconvex | 830 |
| 790 | ....With third component biconvex | 831 |
| 791 | ...+ + - Arrangement | 832 |
| 792 | ...+ + + Arrangement | 833 |
| 793 | ..Two components | 834 |
| 794 | ...+ + Arrangement | 835 |
| 795 | ...+ - Arrangement | 836 |
| 796 | .Single component with multiple elements | 837 838 |
| 797 | . Three or more elements | 839 |
| 798 | . With viewed object or viewed | 840 |
|  | field illumination | 841 |

..Illuminating beam coaxial with lens axis
..Illumination through lens
..With viewed object support
. .Magnifier
...Hand held
.With viewed object support
..On lens supporting handle
..Relatively movable informatory sheet and lens (e.g., reading machine, etc.)
..Flat opaque document or picture
.With lens casing
.Combined with diverse art tool, instrument or machine
..Operation viewed through lens
.With support
..With additional handle
..Lens movable in its plane
...Electromagnetic motive power
. .Body or apparel attached or carried
...Monocular loupe type
..Foldable or collapsible
..With clamp or grip
..Lens mounts
...With temperature compensation or control
...Plural lenses in common carrier selectively operable (e.g., turret type, etc.)
...Adjustable
....With axial adjustment (e.g., adjustable focus, etc.)
.....Electromagnetic or piezoelectric drive
.....Focusing ring
.....Sliding barrels
...Detachably attached (e.g., plate, barrel, etc.)
....Bayonet coupling
...With threads
...With ring
PRISM (INCLUDING MOUNT)
.Fluid filled
.With reflecting surface
..Plural reflecting surfaces
...For binocular or porro-prism
...Roof or roof-angle
.With refracting surface
MIRROR
.With a transmitting property
. Back to back
.Retractable vehicle mirror

| 842 | .Mounted on vehicle having handlebars (e.g., bicycle, motorcycle, etc.) | 872 873 | . .Mirror movable relative to support <br> ...With rotary to linear motion |
| :---: | :---: | :---: | :---: |
| 843 | .Automatically adjustable in response to vehicle position, control, or indicator | 874 | converting mirror adjustment ....With rotation of mirror about perpendicular axes |
| 844 | .On adjustable diverse vehicle portion or accessory | 875 | ...With a rigid handle extending to or near a mirror pivot |
| 845 | .Fluid cooled mirror | 876 | .With rotation of mirror about |
| 846 | . Including specified control or retention of the shape of a mirror surface | 877 | perpendicular axes <br> ...With switch or motor controlling mirror movement |
| 847 | ..Membrane mirror in mechanical contact only at its edge | $\begin{aligned} & 878 \\ & 879 \end{aligned}$ | ....Fluid pressure actuated <br> ...Body or apparel mirror support |
| 848 | ..With structure to minimize internal mirror stress | 880 | ....Having support or apparel engaging head or neck |
| 849 | ..Including a plurality of adjustable mirror supports | 881 | ...With mirror supporting column or sliding adjustment |
| 850 | . Plural mirrors or reflecting | 882 | . With handle |
|  | surfaces | 883 | Laminated or layered mirror |
| 851 | ..Composite or echelon mirrors or light concentrating array | 884 | support |
| 852 | .With a line focus |  | transparent overcoating |
| 853 | ...Light concentrating (e.g., | 885 | ABSORPTION FILTER |
|  | heliostat, etc.), concave, or | 886 | .Fluid |
|  | paraboloidal structure | 887 | .Sequentially additive |
| 854 | ..Identical side mirrors adjustable with respect to a central mirror | $\begin{aligned} & 888 \\ & 889 \end{aligned}$ | .Neutral or graded density <br> .Movable in or out of optical path |
| 855 | ..Identical adjacent mirrors identically supported | $\begin{aligned} & 890 \\ & 891 \end{aligned}$ | .Superimposed or series <br> .Filters in optical parallel |
| 856 | ...With successive reflections |  |  |
| 857 | ..With successive reflections |  | etc.) |
| 858 | ...Including curved mirror surfaces in series | $\begin{aligned} & 892 \\ & 893 \end{aligned}$ | .With support or frame SCREEN (E.G., HALFTONE SCREEN, |
| 859 | ....With concave and convex mirrors in series | 894 | ETC.) <br> OPTICAL APERTURE OR TUBE, OR |
| 860 | To view observer |  | TRANSPARENT CLOSURE |
| 861 | ...With three or more successive reflections | $\begin{aligned} & 895 \\ & 896 \end{aligned}$ | .Submerged object viewer MISCELLANEOUS |
| 862 | ...Including an adjustable mirror |  |  |
| 863 | ....Including a curved mirror |  |  |
| 864 | ..Including adjacent plane and curved mirrors | CRO | EFERENCE ART COLLECTIONS |
| 865 | ..Relatively adjustable CROSS REFERENCE ART COLLECTIONS |  |  |
| 866 | ..Wide angle segmented mirrors | 900 | METHODS |
| 867 | .Concave cylindrical or providing a line focus | 901 | ACOUSTIC HOLOGRAPHY |
| 868 | .With mirror surface of varied radius | $903$ | WITH MAGNET |
| 869 | . . Concave | 904 | MICRO MIRROR |
| 870 | .Fracture resistant (e.g., shatterproof, etc.) |  |  |
| 871 | .With support |  |  |

## FOREIGN ART COLLECTIONS

## FOR 000 CLASS-RELATED FOREIGN DOCUMENTS

Any foreign patents or non-patent literature from subclasses that have been reclassified have been transferred directly to FOR Collections listed below. These Collections contain ONLY foreign patents or non-patent literature. The parenthetical references in the collection titles refer to the abolished subclasses from which these Collections were derived.

FOR 100 DEFLECTING USING A MOVING ELEMENT OR MEDIUM (OFFSETTING OR CHANGING AT LEAST A PORTION OF THE BEAM) (359/196)

FOR 101 .Using a periodically moving element (periodic change of optically reflecting, refracting or diffracting element) (359/197)
FOR 102 ..Particular mount or driver for element (359/198)
FOR 103 ...Particular oscillating driver (359/199)
FOR 104 ...Bearing or shaft for rotary driver (359/200)
FOR 105 .. Plural moving scanning elements (359/201)
FOR 106 ...X-Y scanner (359/202)
FOR 107 ....Having a common axis of rotation (359/203)
FOR 108 ..Utilizing plural light beams (359/204)
FOR 109 ..Having particular focusing element to receive scanned light (359/205)
FOR 110 ...High distortion lens (e.g., fQ lens, etc.) (359/206)
FOR 111 ...Anamorphic element (359/207)
FOR 112 ...Concave reflector (359/208)
FOR 113 .. Including transmissive type moving element (359/209)
FOR 114 ...Having moving lens (359/210)
FOR 115 ...Having moving prism (359/211)
FOR 116 ..Including reflective type moving element (359/212)
FOR 117 ...Having oscillating element (359/213)
FOR 118 ....Single plane mirror element (359/214)

FOR 119 .....With imaging lens (359/215)
FOR 120 ...Having multifaceted rotating element (359/216)
FOR 121 ....With facets parallel to rotation axis (359/217)
FOR 122 .....Having six, seven, or eight facets (359/218)
FOR 123 .....Having five or fewer facets (359/219)
FOR 124 ...Having planar rotating reflector with transverse rotation axis (359/220)
FOR 125 ...Having planar rotating reflector with rotation axis in its plane (359/221)
FOR 126 . By frustrated total internal reflection (359/222)
FOR 127 . By moving a reflective element (359/223)
FOR 128 ..Reflective element moved by deformable support (359/234)
FOR 129 .. Pivoting or moving in circular arc (359/225)
FOR 130 ..Rotating (359/226)
FOR 131 POLARIZATION WITHOUT MODULATION (359/483)
FOR 132 .Time invariant electric, magnetic, or electromagnetic field responsive (e.g., electro-optical, magnetooptical) (359/484)
FOR 133 .Light polarization without any external input (359/485)
FOR 134 .. By grid or dipoles (359/486)
FOR 135 ..By reflection or refraction (e.g., Brewster angle) (359/ 487)

FOR 136 ... With particular medium (359/ 488)

FOR 137 ..Polarization (direction or magnitude) varies over surface of the medium (e.g., vectograph) (359/489)
FOR 138 ..By dichroic medium (359/490)
FOR 139 ...Stain or dye (359/491)
FOR 140 ...Oriented particles (359/492)
FOR 141 ..Glare prevention by discriminating against polarized light (359/493)
FOR 142 .. By birefringent element (359/ 494)

FOR 143 ...For beam deflection or splitting (359/495)
FOR 144 ...Prisms (359/496)

FOR 145 ...Using plural elements (359/ 497)

FOR 146 ....Frequency filter or interference effects (359/498)
FOR 147 ....Using compensation techniques (359/499)
FOR 148 ... With particular material or mounting structure (359/500)
FOR 149 ..By relatively adjustable superimposed or in series polarizers (359/501)
FOR 150 ..With color filter (359/502)

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SOURCE CLASSIFICATION(S) OF PATENTS IN NEWLY ESTABLISHED SUBCLASSES REPORT

Generated by Data Control Division

| New <br> Classification | Number of ORs | Source Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 283/90 | 1 | 359/485 | 88 |
| 356/513 | 1 | 359/497 | 113 |
| 359/239 | 1 | 359/497 | 113 |
| 359/242 | 1 | 359/497 | 113 |
|  | 2 | 359/500 | 52 |
| 359/245 | 1 | 359/497 | 113 |
| 359/256 | 1 | 359/494 | 101 |
|  | 1 | 359/497 | 113 |
|  | 1 | 359/498 | 76 |
| 359/257 | 1 | 359/495 | 142 |
| 359/259 | 1 | 359/497 | 113 |
| 359/260 | 2 | 359/498 | 76 |
| 359/27 | 1 | 359/485 | 88 |
| 359/272 | 1 | 359/497 | 113 |
| 359/283 | 2 | 359/497 | 113 |
| 359/287 | 1 | 359/494 | 101 |
|  | 1 | 359/500 | 52 |
| 359/320 | 2 | 359/501 | 56 |
| 359/350 | 1 | 359/497 | 113 |
| 359/352 | 1 | 359/497 | 113 |
|  | 2 | 359/486 | 75 |
|  | 2 | 359/500 | 52 |
|  | 4 | 359/499 | 47 |
| 359/360 | 1 | 359/498 | 76 |
| 359/361 | 2 | 359/498 | 76 |
| 359/464 | 1 | 359/497 | 113 |
|  | 1 | 359/499 | 47 |
| 359/483.01 | 1 | 359/483 | 28 |
|  | 1 | 359/485 | 88 |
| 359/484.01 | 1 | 359/495 | 142 |
|  | 2 | 359/484 | 154 |
|  | 2 | 359/497 | 113 |
|  | 4 | 359/484 | 154 |
| 359/484.02 | 1 | 359/487 | 184 |
|  | 1 | 359/491 | 50 |
|  | 1 | 359/494 | 101 |
|  | 1 | 359/500 | 52 |
|  | 2 | 359/483 | 28 |
|  | 2 | 359/495 | 142 |
|  | 4 | 359/484 | 154 |
| 359/484.03 | 1 | 359/500 | 52 |
|  | 3 | 359/486 | 75 |
|  | 4 | 359/492 | 45 |

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| New Classification | Number of ORs | Source Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/484.03 | 4 | 359/494 | 101 |
|  | 5 | 359/497 | 113 |
|  | 56 | 359/484 | 154 |
| 359/484.04 | 1 | 359/495 | 142 |
|  | 1 | 359/498 | 76 |
|  | 1 | 359/499 | 47 |
|  | 2 | 359/496 | 34 |
|  | 3 | 359/487 | 184 |
|  | 3 | 359/494 | 101 |
|  | 3 | 359/497 | 113 |
|  | 26 | 359/484 | 154 |
| 359/484.05 | 1 | 359/494 | 101 |
|  | 2 | 359/485 | 88 |
|  | 2 | 359/496 | 34 |
|  | 4 | 359/497 | 113 |
|  | 5 | 359/495 | 142 |
|  | 42 | 359/484 | 154 |
| 359/484.06 | 1 | 359/483 | 28 |
|  | 1 | 359/501 | 56 |
|  | 2 | 359/487 | 184 |
|  | 3 | 359/495 | 142 |
|  | 9 | 359/484 | 154 |
| 359/484.07 | 1 | 359/485 | 88 |
|  | 1 | 359/487 | 184 |
|  | 1 | 359/494 | 101 |
|  | 3 | 359/498 | 76 |
|  | 6 | 359/497 | 113 |
|  | 7 | 359/495 | 142 |
| 359/484.08 | 1 | 359/485 | 88 |
|  | 1 | 359/485 | 88 |
|  | 1 | 359/486 | 75 |
|  | 2 | 359/495 | 142 |
|  | 3 | 359/499 | 47 |
|  | 4 | 359/487 | 184 |
|  | 5 | 359/484 | 154 |
| 359/484.09 | 1 | 359/483 | 28 |
|  | 1 | 359/485 | 88 |
|  | 1 | 359/486 | 75 |
|  | 1 | 359/497 | 113 |
| 359/484.1 | 1 | 359/483 | 28 |
|  | 1 | 359/487 | 184 |
|  | 2 | 359/484 | 154 |
| 359/485.01 | 1 | 359/485 | 88 |

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| New <br> Classification | Number of ORs | Source Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/485.01 | 1 | 359/488 | 37 |
|  | 1 | 359/501 | 56 |
|  | 2 | 359/485 | 88 |
|  | 2 | 359/487 | 184 |
|  | 2 | 359/487 | 184 |
|  | 4 | 359/486 | 75 |
| 359/485.02 | 1 | 359/490 | 54 |
|  | 1 | 359/493 | 42 |
|  | 1 | 359/494 | 101 |
|  | 2 | 359/498 | 76 |
|  | 2 | 359/499 | 47 |
|  | 3 | 359/483 | 28 |
|  | 3 | 359/496 | 34 |
|  | 3 | 359/497 | 113 |
|  | 5 | 359/485 | 88 |
|  | 5 | 359/495 | 142 |
|  | 7 | 359/487 | 184 |
|  | 11 | 359/488 | 37 |
|  | 43 | 359/487 | 184 |
| 359/485.03 | 1 | 359/484 | 154 |
|  | 1 | 359/489 | 60 |
|  | 1 | 359/497 | 113 |
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|  | 2 | 359/492 | 45 |
|  | 2 | 359/494 | 101 |
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|  | 3 | 359/495 | 142 |
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|  | 14 | 359/486 | 75 |
|  | 17 | 359/488 | 37 |
|  | 18 | 359/485 | 88 |
|  | 49 | 359/487 | 184 |
| 359/485.04 | 1 | 359/493 | 42 |
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|  | 1 | 359/498 | 76 |
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|  | 3 | 359/486 | 75 |
|  | 3 | 359/488 | 37 |
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| $\begin{gathered} \text { New } \\ \text { Classification } \end{gathered}$ | Number of ORs | Source Classification | Number of ORs |
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| 359/485.04 | 7 | 359/485 | 88 |
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|  | 29 | 359/486 | 75 |
| 359/485.06 | 1 | 359/494 | 101 |
|  | 1 | 359/495 | 142 |
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|  | 2 | 359/497 | 113 |
|  | 6 | 359/485 | 88 |
|  | 21 | 359/487 | 184 |
| 359/485.07 | 1 | 359/484 | 154 |
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|  | 2 | 359/485 | 88 |
|  | 2 | 359/488 | 37 |
|  | 2 | 359/497 | 113 |
|  | 2 | 359/499 | 47 |
|  | 2 | 359/501 | 56 |
|  | 17 | 359/487 | 184 |
| 359/486.01 | 8 | 359/489 | 60 |
| 359/486. 02 | 1 | 359/489 | 60 |
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|  | 4 | 359/485 | 88 |
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| 359/487.01 | 1 | 359/490 | 54 |
| 359/487.02 | 1 | 359/483 | 28 |
|  | 1 | 359/491 | 50 |

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| New <br> Classification | Number of ORs | Source Classification | Number of ORs |
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| 359/487.02 | 1 | 359/493 | 42 |
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|  | 3 | 359/499 | 47 |
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|  | 4 | 359/500 | 52 |
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| 359/487.04 | 1 | 359/483 | 28 |
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|  | 1 | 359/492 | 45 |
|  | 1 | 359/501 | 56 |
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|  | 28 | 359/492 | 45 |
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|  | 2 | 359/495 | 142 |
|  | 2 | 359/497 | 113 |
| 359/489.03 | 1 | 359/497 | 113 |
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|  | 3 | 359/494 | 101 |
|  | 13 | 359/499 | 47 |
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|  | 1 | 359/497 | 113 |
|  | 1 | 359/501 | 56 |
|  | 2 | 359/494 | 101 |
|  | 3 | 359/495 | 142 |
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| 359/489.06 | 1 | 359/487 | 184 |
|  | 1 | 359/496 | 34 |
|  | 1 | 359/497 | 113 |
|  | 2 | 359/498 | 76 |
|  | 3 | 359/486 | 75 |
|  | 4 | 359/485 | 88 |
|  | 5 | 359/494 | 101 |
|  | 12 | 359/495 | 142 |
| 359/489.07 | 1 | 359/484 | 154 |
|  | 2 | 359/501 | 56 |
|  | 12 | 359/496 | 34 |
|  | 12 | 359/500 | 52 |
|  | 14 | 359/498 | 76 |
|  | 23 | 359/497 | 113 |
|  | 28 | 359/494 | 101 |

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| New Classification | Number of ORs | Source Classification | Number of ORs |
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| 359/489.07 | 29 | 359/495 | 142 |
| 359/489. 08 | 1 | 359/487 | 184 |
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|  | 2 | 359/495 | 142 |
|  | 2 | 359/497 | 113 |
|  | 12 | 359/495 | 142 |
| 359/489.09 | 1 | 359/498 | 76 |
|  | 2 | 359/495 | 142 |
|  | 2 | 359/501 | 56 |
|  | 2 | 359/502 | 4 |
|  | 3 | 359/497 | 113 |
|  | 4 | 359/487 | 184 |
|  | 4 | 359/494 | 101 |
|  | 10 | 359/496 | 34 |
|  | 30 | 359/495 | 142 |
| 359/489.11 | 1 | 359/483 | 28 |
|  | 1 | 359/494 | 101 |
|  | 1 | 359/495 | 142 |
|  | 1 | 359/500 | 52 |
|  | 3 | 359/487 | 184 |
|  | 4 | 359/495 | 142 |
| 359/489.12 | 1 | 359/495 | 142 |
|  | 1 | 359/495 | 142 |
|  | 1 | 359/497 | 113 |
|  | 1 | 359/501 | 56 |
|  | 2 | 359/500 | 52 |
|  | 4 | 359/498 | 76 |
|  | 6 | 359/494 | 101 |
| 359/489.13 | 3 | 359/500 | 52 |
|  | 4 | 359/494 | 101 |
| 359/489.14 | 1 | 359/494 | 101 |
|  | 1 | 359/497 | 113 |
|  | 2 | 359/483 | 28 |
|  | 2 | 359/501 | 56 |
| 359/489.15 | 1 | 359/485 | 88 |
|  | 1 | 359/494 | 101 |
|  | 1 | 359/500 | 52 |
|  | 2 | 359/498 | 76 |
|  | 6 | 359/497 | 113 |
|  | 6 | 359/497 | 113 |
| 359/489.16 | 1 | 359/494 | 101 |
|  | 3 | 359/497 | 113 |

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PROJECT E-7273
SOURCE CLASSIFICATION(S) OF PATENTS IN NEWLY ESTABLISHED SUBCLASSES REPORT

Generated by Data Control Division

| New <br> Classification | Number of ORs | Source Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/489.17 | 1 | 359/497 | 113 |
|  | 1 | 359/497 | 113 |
| 359/489.18 | 1 | 359/501 | 56 |
|  | 2 | 359/494 | 101 |
|  | 2 | 359/498 | 76 |
| 359/489.19 | 2 | 359/485 | 88 |
|  | 2 | 359/497 | 113 |
|  | 3 | 359/497 | 113 |
|  | 3 | 359/498 | 76 |
|  | 3 | 359/500 | 52 |
|  | 4 | 359/501 | 56 |
|  | 23 | 359/498 | 76 |
| 359/489.2 | 1 | 359/494 | 101 |
|  | 2 | 359/500 | 52 |
|  | 4 | 359/501 | 56 |
|  | 6 | 359/485 | 88 |
|  | 6 | 359/500 | 52 |
| 359/490.01 | 4 | 359/501 | 56 |
| 359/490.02 | 1 | 359/498 | 76 |
|  | 2 | 359/501 | 56 |
|  | 12 | 359/501 | 56 |
| 359/490.03 | 1 | 359/483 | 28 |
|  | 1 | 359/501 | 56 |
| 359/491. 01 | 1 | 359/483 | 28 |
|  | 1 | 359/485 | 88 |
|  | 1 | 359/501 | 56 |
| 359/493. 01 | 1 | 359/487 | 184 |
| 362/310 | 1 | 359/487 | 184 |
| 362/560 | 1 | 359/501 | 56 |

## FEBRUARY 1, 2011

PROJECT E-7273

## DISPOSITION CLASSIFICATION(S) OF PATENTS FROM ABOLISHED SUBCLASSES REPORT

Generated by Data Control Division

| Source <br> classification | Number of ORs | New <br> Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/496 | 34 | 359/484.05 | 2 |
| 359/494 | 101 | 359/484.05 | 1 |
| 359/484 | 154 | 359/484.1 | 2 |
|  |  | 359/485.03 | 1 |
| 359/490 | 54 | 359/487.02 | 16 |
| 359/483 | 28 | 359/484.02 | 2 |
| 359/494 | 101 | 359/485.03 | 2 |
| 359/486 | 75 | 359/485.05 | 29 |
| 359/499 | 47 | 359/489.05 | 9 |
| 359/496 | 34 | 359/489.08 | 1 |
| 359/495 | 142 | 359/489.09 | 30 |
|  |  | 359/484.08 | 2 |
| 359/494 | 101 | 359/486.03 | 1 |
| 359/501 | 56 | 359/484.06 | 1 |
| 359/485 | 88 | 359/485.06 | 6 |
|  |  | 359/485.07 | 2 |
| 359/500 | 52 | 359/489.01 | 3 |
| 359/501 | 56 | 359/489.14 | 2 |
|  |  | 359/489.2 | 4 |
| 359/484 | 154 | 359/484.05 | 42 |
| 359/495 | 142 | 359/485.02 | 5 |
|  |  | 359/487.02 | 5 |
| 359/502 | 4 | 359/487.02 | 1 |
| 359/495 | 142 | 359/489.02 | 2 |
| 359/501 | 56 | 359/486.02 | 1 |
| 359/492 | 45 | 359/487.05 | 1 |
| 359/494 | 101 | 359/489.06 | 5 |
|  |  | 359/489.01 | 10 |
| 359/486 | 75 | 359/485.03 | 3 |
| 359/501 | 56 | 359/489.01 | 1 |
| 359/495 | 142 | 359/489. 08 | 12 |
| 359/494 | 101 | 359/256 | 1 |
| 359/500 | 52 | 359/352 | 2 |
| 359/497 | 113 | 359/352 | 1 |
| 359/498 | 76 | 359/256 | 1 |
|  |  | 359/260 | 2 |
| 359/499 | 47 | 359/464 | 1 |
| 359/485 | 88 | 359/27 | 1 |
| 359/501 | 56 | 359/320 | 2 |
| 359/494 | 101 | 359/484.02 | 1 |
| 359/483 | 28 | 359/484.09 | 1 |
| 359/495 | 142 | 359/489.05 | 3 |
|  |  | 359/484.01 | 1 |

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PROJECT E-7273

## DISPOSITION CLASSIFICATION(S) OF PATENTS FROM ABOLISHED SUBCLASSES REPORT

Generated by Data Control Division

| Source | Number of ORs | New <br> Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/499 | 47 | 359/484. 08 | 3 |
| 359/501 | 56 | 359/485.04 | 3 |
| 359/488 | 37 | 359/485.04 | 3 |
| 359/495 | 142 | 359/485.07 | 1 |
| 359/492 | 45 | 359/487.06 | 28 |
| 359/501 | 56 | 359/489.18 | 1 |
| 359/498 | 76 | 359/484.07 | 3 |
| 359/493 | 42 | 359/485.04 | 1 |
| 359/495 | 142 | 359/489.07 | 29 |
| 359/501 | 56 | 359/489. 09 | 2 |
| 359/490 | 54 | 359/485.02 | 1 |
| 359/493 | 42 | 359/487.02 | 1 |
| 359/498 | 76 | 359/488.01 | 1 |
| 359/501 | 56 | 359/491. 01 | 1 |
| 359/483 | 28 | 359/484. 06 | 1 |
| 359/502 | 4 | 359/485.06 | 1 |
| 359/497 | 113 | 359/489. 08 | 2 |
|  |  | 359/489.17 | 1 |
| 359/499 | 47 | 359/487.02 | 3 |
| 359/483 | 28 | 359/487.02 | 1 |
| 359/494 | 101 | 359/489.03 | 3 |
| 359/498 | 76 | 359/489. 06 | 2 |
| 359/484 | 154 | 359/489. 07 | 1 |
| 359/487 | 184 | 359/484. 06 | 2 |
| 359/492 | 45 | 359/487.02 | 5 |
| 359/495 | 142 | 359/487.04 | 6 |
| 359/491 | 50 | 359/487.02 | 45 |
| 359/501 | 56 | 359/487.04 | 1 |
| 359/491 | 50 | 359/487.06 | 1 |
| 359/500 | 52 | 359/489.03 | 2 |
| 359/495 | 142 | 359/489.11 | 4 |
| 359/492 | 45 | 359/487.06 | 3 |
| 359/483 | 28 | 359/483.01 | 1 |
| 359/490 | 54 | 359/487.01 | 1 |
| 359/499 | 47 | 359/489.03 | 2 |
| 359/497 | 113 | 359/283 | 2 |
|  |  | 359/272 | 1 |
| 359/499 | 47 | 359/352 | 4 |
| 359/498 | 76 | 359/360 | 1 |
|  |  | 359/361 | 2 |
| 359/501 | 56 | 362/560 | 1 |
| 359/497 | 113 | 359/484.09 | 1 |
| 359/489 | 60 | 359/486. 03 | 16 |

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PROJECT E-7273
DISPOSITION CLASSIFICATION(S) OF PATENTS FROM ABOLISHED SUBCLASSES REPORT

Generated by Data Control Division

| Source | Number of ORs | New <br> Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/497 | 113 | 359/489.14 | 1 |
| 359/484 | 154 | 359/484. 02 | 4 |
| 359/485 | 88 | 359/484. 05 | 2 |
| 359/487 | 184 | 359/484. 07 | 1 |
|  |  | 359/485.07 | 17 |
| 359/485 | 88 | 359/485.01 | 2 |
|  |  | 359/486.03 | 4 |
| 359/497 | 113 | 359/487.04 | 6 |
| 359/487 | 184 | 359/489.09 | 4 |
| 359/498 | 76 | 359/484.04 | 1 |
| 359/495 | 142 | 359/484. 05 | 5 |
| 359/497 | 113 | 359/485.03 | 1 |
| 359/498 | 76 | 359/487.02 | 2 |
|  |  | 359/489. 07 | 14 |
| 359/485 | 88 | 359/489.15 | 1 |
| 359/488 | 37 | 359/485.03 | 17 |
| 359/495 | 142 | 359/485.06 | 1 |
| 359/486 | 75 | 359/487.03 | 2 |
| 359/498 | 76 | 359/489.04 | 2 |
| 359/483 | 28 | 359/489.11 | 1 |
| 359/500 | 52 | 359/485. 05 | 1 |
| 359/501 | 56 | 359/485.07 | 2 |
| 359/483 | 28 | 359/486.03 | 1 |
| 359/485 | 88 | 359/487.02 | 3 |
| 359/489 | 60 | 359/487.02 | 2 |
| 359/497 | 113 | 359/489.03 | 1 |
| 359/499 | 47 | 359/489.04 | 4 |
| 359/497 | 113 | 359/489.19 | 3 |
| 359/488 | 37 | 359/485. 05 | 1 |
| 359/494 | 101 | 359/489.04 | 1 |
| 359/501 | 56 | 359/489.05 | 1 |
| 359/487 | 184 | 359/485.02 | 7 |
| 359/494 | 101 | 359/287 | 1 |
|  |  | 359/489.12 | 6 |
| 359/500 | 52 | 359/489.13 | 3 |
|  |  | 359/489.15 | 1 |
| 359/498 | 76 | 359/485.04 | 1 |
| 359/483 | 28 | 359/489.14 | 2 |
| 359/492 | 45 | 359/484.03 | 4 |
| 359/486 | 75 | 359/485.04 | 3 |
| 359/494 | 101 | 359/484.03 | 4 |
| 359/497 | 113 | 359/485.06 | 2 |
| 359/485 | 88 | 359/489.05 | 1 |

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PROJECT E-7273
DISPOSITION CLASSIFICATION(S) OF PATENTS FROM ABOLISHED SUBCLASSES REPORT

Generated by Data Control Division

| Source | Number of ORs | New | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/494 | 101 | 359/489.11 | 1 |
| 359/498 | 76 | 359/489.18 | 2 |
| 359/497 | 113 | 359/484.01 | 2 |
| 359/499 | 47 | 359/486.03 | 1 |
| 359/487 | 184 | 359/489.06 | 1 |
| 359/497 | 113 | 359/489.16 | 3 |
| 359/498 | 76 | 359/489.19 | 23 |
| 359/484 | 154 | 359/484.03 | 56 |
| 359/488 | 37 | 359/485.01 | 1 |
| 359/498 | 76 | 359/485.03 | 1 |
| 359/485 | 88 | 359/486. 02 | 3 |
| 359/492 | 45 | 359/487.04 | 1 |
| 359/497 | 113 | 359/489.06 | 1 |
| 359/489 | 60 | 359/486.01 | 8 |
| 359/486 | 75 | 359/485.05 | 10 |
| 359/499 | 47 | 359/489.01 | 1 |
| 359/497 | 113 | 359/350 | 1 |
|  |  | 359/245 | 1 |
| 359/495 | 142 | 359/257 | 1 |
| 359/497 | 113 | 359/259 | 1 |
| 359/485 | 88 | 283/90 | 1 |
| 359/498 | 76 | 359/489.12 | 4 |
| 359/500 | 52 | 359/489.19 | 3 |
| 359/496 | 34 | 359/485.02 | 3 |
| 359/490 | 54 | 359/487.05 | 2 |
| 359/500 | 52 | 359/484. 02 | 1 |
| 359/494 | 101 | 359/484.07 | 1 |
|  |  | 359/484.04 | 3 |
| 359/485 | 88 | 359/485.02 | 5 |
| 359/483 | 28 | 359/488. 01 | 3 |
| 359/487 | 184 | 359/485.02 | 43 |
| 359/494 | 101 | 359/489.08 | 1 |
| 359/490 | 54 | 359/486. 02 | 1 |
| 359/485 | 88 | 359/489.2 | 6 |
| 359/484 | 154 | 359/484.04 | 26 |
| 359/485 | 88 | 359/485.05 | 2 |
| 359/488 | 37 | 359/485.07 | 2 |
| 359/500 | 52 | 359/487. 02 | 4 |
| 359/497 | 113 | 359/489.04 | 1 |
|  |  | 359/489.07 | 23 |
| 359/500 | 52 | 359/489.2 | 2 |
| 359/494 | 101 | 359/489.09 | 4 |
| 359/496 | 34 | 359/484.04 | 2 |

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PROJECT E-7273

## DISPOSITION CLASSIFICATION(S) OF PATENTS FROM ABOLISHED SUBCLASSES REPORT

Generated by Data Control Division

| Source | Number | New | Number |
| :---: | :---: | :---: | :---: |
| Classification | of ORs | Classification | of ORs |
| 359/487 | 184 | 359/484.08 | 4 |
| 359/485 | 88 | 359/485.04 | 7 |
| 359/487 | 184 | 359/487.05 | 1 |
| 359/485 | 88 | 359/487.05 | 1 |
| 359/484 | 154 | 359/485.07 | 1 |
| 359/494 | 101 | 359/489.18 | 2 |
| 359/490 | 54 | 359/487.02 | 2 |
| 359/495 | 142 | 359/489. 09 | 2 |
| 359/498 | 76 | 359/489.15 | 2 |
| 359/495 | 142 | 359/489.11 | 1 |
| 359/487 | 184 | 362/310 | 1 |
| 359/499 | 47 | 359/485.07 | 2 |
|  |  | 359/485.02 | 2 |
|  |  | 359/484.04 | 1 |
| 359/501 | 56 | 359/485.03 | 1 |
| 359/485 | 88 | 359/489.03 | 2 |
| 359/491 | 50 | 359/484.02 | 1 |
| 359/483 | 28 | 359/485.03 | 4 |
| 359/484 | 154 | 359/487.04 | 1 |
| 359/501 | 56 | 359/488.01 | 5 |
| 359/494 | 101 | 359/489.07 | 28 |
| 359/492 | 45 | 359/486.02 | 1 |
| 359/498 | 76 | 359/487.05 | 2 |
| 359/485 | 88 | 359/488.01 | 4 |
| 359/487 | 184 | 359/489.08 | 1 |
|  |  | 359/485.01 | 2 |
|  |  | 359/485.03 | 49 |
| 359/494 | 101 | 359/487.04 | 3 |
| 359/485 | 88 | 359/487.04 | 1 |
| 359/493 | 42 | 359/488.01 | 39 |
| 359/484 | 154 | 359/484.06 | 9 |
| 359/485 | 88 | 359/485.03 | 18 |
| 359/497 | 113 | 359/487.06 | 1 |
| 359/495 | 142 | 359/489.08 | 2 |
| 359/498 | 76 | 359/487.04 | 3 |
| 359/499 | 47 | 359/489.03 | 13 |
| 359/497 | 113 | 359/489.15 | 6 |
| 359/501 | 56 | 359/489.19 | 4 |
| 359/494 | 101 | 359/489.14 | 1 |
| 359/485 | 88 | 359/485.01 | 1 |
| 359/484 | 154 | 359/484.01 | 2 |
| 359/498 | 76 | 359/489.19 | 3 |
| 359/494 | 101 | 359/489.2 | 1 |

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PROJECT E-7273

## DISPOSITION CLASSIFICATION(S) OF PATENTS FROM ABOLISHED SUBCLASSES REPORT

Generated by Data Control Division

| Source <br> classification | Number of ORs | New <br> Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| Classification | of ORS | Classification |  |
| 359/500 | 52 | 359/489.2 | 6 |
| 359/501 | 56 | 359/490. 02 | 2 |
| 359/489 | 60 | 359/486.02 | 1 |
| 359/490 | 54 | 359/487. 05 | 1 |
| 359/500 | 52 | 359/242 | 2 |
| 359/486 | 75 | 359/352 | 2 |
| 359/497 | 113 | 359/256 | 1 |
| 359/487 | 184 | 359/489.11 | 3 |
| 359/498 | 76 | 359/490.02 | 1 |
| 359/497 | 113 | 359/485.04 | 1 |
| 359/500 | 52 | 359/485.04 | 2 |
| 359/488 | 37 | 359/485.06 | 2 |
| 359/485 | 88 | 359/484.07 | 1 |
| 359/495 | 142 | 359/485.03 | 3 |
| 359/496 | 34 | 359/485.04 | 1 |
| 359/499 | 47 | 359/487.06 | 1 |
| 359/496 | 34 | 359/489.09 | 10 |
| 359/497 | 113 | 359/489.09 | 3 |
| 359/495 | 142 | 359/484.04 | 1 |
| 359/486 | 75 | 359/485.03 | 14 |
| 359/497 | 113 | 359/485.07 | 2 |
| 359/491 | 50 | 359/487.04 | 1 |
| 359/484 | 154 | 359/484.01 | 4 |
| 359/487 | 184 | 359/484.02 | 1 |
| 359/490 | 54 | 359/487.06 | 19 |
| 359/494 | 101 | 359/489. 05 | 2 |
| 359/500 | 52 | 359/489.07 | 12 |
| 359/502 | 4 | 359/489.09 | 2 |
| 359/501 | 56 | 359/489. 12 | 1 |
| 359/494 | 101 | 359/485. 02 | 1 |
| 359/487 | 184 | 359/485.04 | 19 |
|  |  | 359/485.06 | 21 |
| 359/496 | 34 | 359/489. 02 | 1 |
| 359/485 | 88 | 359/489.19 | 2 |
| 359/483 | 28 | 359/491. 01 | 1 |
| 359/486 | 75 | 359/484. 09 | 1 |
| 359/483 | 28 | 359/484.1 | 1 |
| 359/500 | 52 | 359/485.03 | 2 |
| 359/498 | 76 | 359/489. 09 | 1 |
| 359/497 | 113 | 359/489.12 | 1 |
| 359/487 | 184 | 359/493.01 | 1 |
| 359/500 | 52 | 359/484.03 | 1 |
| 359/495 | 142 | 359/484.07 | 7 |

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PROJECT E-7273

## DISPOSITION CLASSIFICATION(S) OF PATENTS FROM ABOLISHED SUBCLASSES REPORT

Generated by Data Control Division

| Source | Number of ORs | New <br> Classification | Number of 0 Rs |
| :---: | :---: | :---: | :---: |
| classification |  | Classification |  |
| 359/493 | 42 | 359/485.02 | 1 |
| 359/494 | 101 | 359/486. 02 | 2 |
| 359/483 | 28 | 359/487.04 | 1 |
| 359/497 | 113 | 359/488.01 | 2 |
| 359/491 | 50 | 359/486.03 | 1 |
| 359/497 | 113 | 359/489.05 | 1 |
| 359/485 | 88 | 359/489.06 | 4 |
| 359/494 | 101 | 359/489.13 | 4 |
|  |  | 359/489.15 | 1 |
| 359/483 | 28 | 359/490.03 | 1 |
| 359/485 | 88 | 359/483.01 | 1 |
|  |  | 359/484.08 | 1 |
| 359/489 | 60 | 359/486.03 | 1 |
| 359/495 | 142 | 359/489.12 | 1 |
| 359/491 | 50 | 359/487. 02 | 1 |
| 359/500 | 52 | 359/287 | 1 |
| 359/497 | 113 | 359/239 | 1 |
| 359/486 | 75 | 359/484.03 | 3 |
| 359/497 | 113 | 359/484.04 | 3 |
|  |  | 359/484.05 | 4 |
| 359/483 | 28 | 359/485.02 | 3 |
| 359/494 | 101 | 359/485.06 | 1 |
| 359/489 | 60 | 359/486.02 | 31 |
| 359/500 | 52 | 359/489.11 | 1 |
| 359/501 | 56 | 359/485.01 | 1 |
| 359/488 | 37 | 359/485.02 | 11 |
| 359/485 | 88 | 359/484.09 | 1 |
| 359/492 | 45 | 359/485.03 | 2 |
| 359/483 | 28 | 359/485.05 | 1 |
| 359/494 | 101 | 359/487.02 | 6 |
| 359/500 | 52 | 359/487.06 | 1 |
| 359/486 | 75 | 359/489.06 | 3 |
| 359/497 | 113 | 359/485.02 | 3 |
| 359/496 | 34 | 359/489.06 | 1 |
| 359/494 | 101 | 359/489.16 | 1 |
| 359/497 | 113 | 359/487.02 | 4 |
|  |  | 359/489.02 | 2 |
| 359/500 | 52 | 359/489.12 | 2 |
| 359/501 | 56 | 359/490.03 | 1 |
| 359/498 | 76 | 359/485.02 | 2 |
| 359/490 | 54 | 359/485.03 | 2 |
| 359/496 | 34 | 359/489.07 | 12 |
| 359/487 | 184 | 359/484.04 | 3 |

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PROJECT E-7273
DISPOSITION CLASSIFICATION(S) OF PATENTS
FROM ABOLISHED SUBCLASSES REPORT

| Source | Number of ORs | New <br> Classification | Number of ORs |
| :---: | :---: | :---: | :---: |
| 359/486 | 75 | 359/484 08 | 1 |
| 359/489 | 60 | 359/485.03 | 1 |
| 359/501 | 56 | 359/490.02 | 12 |
| 359/485 | 88 | 359/491.01 | 1 |
| 359/497 | 113 | 359/484.07 | 6 |
| 359/487 | 184 | 359/484.1 | 1 |
| 359/490 | 54 | 359/487.04 | 9 |
| 359/494 | 101 | 359/487.06 | 2 |
| 359/496 | 34 | 359/488.01 | 1 |
| 359/501 | 56 | 359/489.07 | 2 |
| 359/486 | 75 | 359/485.01 | 4 |
| 359/497 | 113 | 359/489.19 | 2 |
| 359/501 | 56 | 359/490.01 | 4 |
| 359/497 | 113 | 359/464 | 1 |
|  |  | 359/242 | 1 |
|  |  | 356/513 | 1 |
|  |  | 359/484.03 | 5 |
| 359/495 | 142 | 359/484.06 | 3 |
| 359/483 | 28 | 359/486.02 | 3 |
| 359/495 | 142 | 359/489.06 | 12 |
|  |  | 359/484.02 | 2 |
| 359/484 | 154 | 359/484.08 | 5 |

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PROJECT E-7372
C. CHANGES TO THE US-TO-IPC CONCORDANCE

| U. S. Class | Subclass | I. P. C. <br> Subclass | Notation |
| :---: | :---: | :---: | :---: |
| 359 | 483.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.02 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.03 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.04 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.05 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.06 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.07 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.08 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.09 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 484.1 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 485.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 485.02 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 485.03 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 485.04 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 485.05 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 485.06 | G02B | 5/30 |
|  |  |  | 27/28 |

## C. CHANGES TO THE US-TO-IPC CONCORDANCE

| U. S. <br> Class | Subclass | I. P. C. <br> Subclass | Notation |
| :---: | :---: | :---: | :---: |
| 359 | 485.07 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 486.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 486.02 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 486.03 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 487.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 487.02 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 487.03 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 487.04 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 487.05 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 487.06 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 488.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.02 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.03 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.04 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.05 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.06 | G02B | 5/30 |
|  |  |  | 27/28 |

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PROJECT E-7372
C. CHANGES TO THE US-TO-IPC CONCORDANCE

| U. S. <br> Class | Subclass | I. P. C. <br> Subclass | Notation |
| :---: | :---: | :---: | :---: |
| 359 | 489.07 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.08 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.09 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.1 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.11 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.12 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.13 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.14 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.15 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.16 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.17 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.18 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.19 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 489.2 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 490.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 490.02 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 490.03 | G02B | 5/30 |
|  |  |  | 27/28 |

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C. CHANGES TO THE US-TO-IPC CONCORDANCE

| U. S. |  | I. P. C. |  |
| :---: | :---: | :---: | :---: |
| Class | Subclass | Subclass | Notation |
| 359 | 491.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 492.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 493.01 | G02B | 5/30 |
|  |  |  | 27/28 |
|  | 494.01 | G02B | 5/30 |
|  |  |  | 27/28 |

## D. CHANGES TO THE DEFINITIONS

## CLASS 40 - CARD, PICTURE, OR SIGN EXHIBITING

Definitions Modified:

Subclass 434: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for nonmodulating polarizing devices.

Subclass 541: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for nonmodulating polarizing devices.

## D. CHANGES TO THE DEFINITIONS

## CLASS 106 - COMPOSITIONS: COATING OR PLASTIC

Definitions Modified:

Class Definition: Under SECTION III, REFERENCES TO OTHER CLASSES, SEE OR SEARCH CLASS, directly under the reference to Class 349

Delete:

The first occurring reference to Class 359

Insert:
359, Optical: Systems and Elements, subclasses 321+ for an optical modulator with significant composition, subclasses 487.01-487.06 for polarizing by dichroic medium, and subclasses 489.01-489.19 for polarization by birefringent element of particular material. (For coating or plastic compositions elsewhere classified.)

## D. CHANGES TO THE DEFINITIONS

## CLASS 250 - RADIANT ENERGY

Definitions Modified:

Subclass 341.3: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarizers, per se.

Subclass 559.09: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarizers, per se.

## D. CHANGES TO THE DEFINITIONS

## CLASS 313 - ELECTRIC LAMP AND DISCHARGE DEVICES

Definitions Modified:

Subclass 112: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for light polarizers and subclasses 350+ and 885+ for optical filters.

## D. CHANGES TO THE DEFINITIONS

## CLASS 343 - COMMUNICATIONS: RADIO WAVE ANTENNAS

Definitions Modified:

## Subclass 700: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for optical polarizers, subclasses 642+ for optical lenses, subclasses 838+ for optical reflectors and subclasses 350+ and 885+ for optical filters.

Subclass 756: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for optical polarizers.

Subclass 909: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for optical polarizers, subclasses 642+ for optical lenses, and subclasses 350+ and 885+ for optical filters.

## D. CHANGES TO THE DEFINITIONS

## CLASS 351 - OPTICS: EYE EXAMINING, VISION TESTING AND CORRECTING

Definitions Modified:

Subclass 44: In the (1) Note

Delete:

See Class 359, subclasses 483+ for polarizers, subclasses 601+ for optical elments and systems for reducing glare and subclasses 885+ for optical filters.

Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarizers, subclasses 601+ for optical elements and systems for reducing glare and subclasses 885+ for optical filters.

Subclass 49: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclass 465 for polarizing device used in viewing stereoscopic pictures; and subclasses 483.01 through 494.01 for polarizing devices generally.

Subclass 163: Under SEE OR SEARCH CLASS:

Delete:

## D. CHANGES TO THE DEFINITIONS

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for light polarizers and subclasses $885+$ for optical filters. See also (1) Note above.

Subclass 215: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarizing devices generally.

Subclass 232: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarizing devices generally.

## D. CHANGES TO THE DEFINITIONS

## CLASS 353 - OPTICS: IMAGE PROJECTORS

Definitions Modified:

Subclass 20: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarizers, per se, and subclasses 577+ for interference filters, per se.

## CLASS 356 - OPTICS: MEASURING AND TESTING

Definitions Modified:

Class Definition: In Section IV, References to Other Classes, under SEE OR SEARCH CLASS:

Delete:

The first occurring reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 350+ for optical elements usable in the infrared or ultraviolet range, subclasses 362+ for compound lens systems including telescopes, microscopes, or periscopes, subclasses 396+ for microscope slides, subclasses 436+ for scale or indicia reading, subclasses 483.01 through 494.01 for polarization type devices, subclasses 290+ for light control systems which after an optical medium surface, or interface, subclasses 566+ for diffractions gratings subclasses 557+ for light interference systems, subclass 615 for light dispersion systems, subclasses 645+ lenses, particularly subclass 801 for lenses combined with illumination and a viewed object support, subclasses 227+ for light control systems using an opaque element or medium movable in or through the light path, subclasses $831+$ for prisms and their mounts, subclasses 838+ for reflectors, and subclasses 885+ for optical filters. (See Lines With Other Classes, B, "Testing and Measuring Subcombinations Provided for Elsewhere.")

Subclass 33: In the (1) Note

Delete:

483

Insert:
483.01 through 494.01,

Subclass 34: Under SEE OR SEARCH CLASS:

Delete:

## D. CHANGES TO THE DEFINITIONS

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarizing structure generally. See also (1) Note of subclass 33.

Subclass 225: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 227+ for light control by opaque elements movable in a light path, subclasses 483.01 through 494.01 for light polarization devices, subclasses 558+ for light diffraction elements, subclass 615 for light dispersion elements, subclasses 642+ for lenses, subclass 831 for light reflectors, subclasses 885+ for light filters, and subclasses 894+ for optical apertures and tubes.

Subclass 364: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclass 437 for scales or indicia reading which utilize a polarizer element; and subclasses 483.01 through 494.01 for optical elements of the polarizer type.

Subclass 366: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

## D. CHANGES TO THE DEFINITIONS

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 which includes series polarizers relatively adjustable.

Subclass 368: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 246+, 281+, and 483.01 through 494.01 for electromagnetic and electrostatic type optical elements which rotate the plane of polarization of polarized light.

Subclass 450: Under SEE OR SEARCH CLASS:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclass 370 for an interference microscope; subclass 489.19 for an optical device using interference effects with polarized light, not limited to measuring or testing; and subclass 577 for an optical modifying device, in general, which utilizes the phenomenon of light interference.

## D. CHANGES TO THE DEFINITIONS

## CLASS 359-OPTICAL: SYSTEMS AND ELEMENTS

Definitions Abolished

Subclasses
483-502

Definitions Modified

Subclass 204.3: Under SEE OR SEARCH THIS CLASS, SUBCLASS
Delete:

483, through 502,

Insert:
483.01, through 494.01,

Subclass 250: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

497,

Insert:
489.01, through 489.15, for polarization achieved by plural birefringent elements.

Subclass 252:

Delete:

488,

Insert:
485.01, through 489.15,

## D. CHANGES TO THE DEFINITIONS

Subclass 254: Under the (1) Note
Delete:

Also, see subclasses 488 and 500.

Subclass 255: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

484,

Insert:
484.01, through 484.1

Subclass 282: Under SEE OR SEARCH THIS CLASS, SUBCLASS, in the reference to subclass 254, directly after 254,

Delete:

488, and 500,

Insert:
and 489.2,

Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The entire reference to subclass 487

Insert:
485.03, for layered structure or plural mediums formed for polarization without modulation.

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Delete:

The entire reference to subclass 490+

Insert:
487.01, through 487.06, for layered structures formed with at least one layer of dichroic material where additional layers may be provided for purposes such as protection or particular bonding and for layered structures formed for interference effects.

Delete:

The entire reference to subclass 497+

Insert:
489.15, through 489.19, for plural mediums including a birefringent medium which is not field responsive.

Subclass 301: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The entire reference to subclass 495

Insert:
489.08, through 489.13, for birefringent element beam deflection or splitting for polarization without modulation or external input.

Subclass 351: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The entire reference to subclass 495

Insert:
489.08, through 489.13, for birefringent element beam deflection or splitting for polarization without modulation or external input.

## D. CHANGES TO THE DEFINITIONS

## Subclass 371: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The reference to Class 483+

Insert:
483.01, through 494.01, for optics, systems, and elements for polarization of light or using polarized light.

Subclass 386: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The reference to subclass 483+

Insert:
483.01, through 494.01, for systems and elements for the polarization of light without modulation.

Subclass 437: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The reference to subclass 485+

Insert:
483.01, through 494.01, for specific polarizing elements in polarization without modulation.

Subclass 465: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The reference to subclass 483+

## D. CHANGES TO THE DEFINITIONS

Insert:
483.01, through 494.01, for optics, systems, and elements for polarization of light or using polarized light.

Subclass 573: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The reference to subclass 483+

Insert:
483.01, through 494.01, for polarization without modulation.

Subclass 577: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The entire reference to subclass 498

Insert:
489.19, for frequency filter or interference effect where the light is polarized.

Subclass 591: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The reference to subclass 483+

Insert:
483.01, through 494.01, for light control with polarizers.

Subclass 601: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

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## D. CHANGES TO THE DEFINITIONS

The entire reference to subclass 493

Insert:
488.01, for glare prevention by means of polarizers.

Subclass 603: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The entire reference to subclass 493

Insert:
488.01, for glare prevention by means of polarizers.

Subclass 885: Under SEE OR SEARCH THIS CLASS, SUBCLASS

Delete:

The entire reference to Class 502.
Insert:
491.01, for polarizers combined with color filter means.

Definitions Established

### 483.01 POLARIZATION WITHOUT MODULATION:

This subclass is indented under the class definition. Subject matter wherein a polarization of an incident light beam is produced or modified in a time invariant fashion as a result of passing through an optical device.
(1) Note. Where both a polarizing device and a composition are claimed, the patent is classified here and cross-referenced to class 252, subclass 585.
(2) Note. Where a method of making the polarizing device is claimed as well as the polarizing device, the patent is classified here and cross-referenced to any other class providing for the method.

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(3) Note. The nominal recitation of a polarizing area in the form of a design, image, etc., or specifics of a polarization element (e.g., polarization light characteristics) is sufficient to include this subject matter in these subclasses. However, the nominal recitation of a polarization element in an optical system is not sufficient to include the subject matter in these subclasses and should be classified elsewhere where such combination meets the class requirements.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

204.3, for polarized light to be deflected using moving element

246, through 258, for polarization with modulation by electro-optic devices with applied time variant electric signal.
281, through 289, for polarization with modulation by magneto-optic devices with applied time variant magnetic signal.

301, for light wave directional control of polarized light.
352, for a polarizing element having significant infrared or ultraviolet properties.
371, and 386, for compound lens systems combined with polarizers.
437, for polarizers used in a scale or indicia reading.
465, for polarizers used in stereoscopic systems.
484.01, for polarization using an applied external time-invariant electric, magnetic, or electromagnetic signal.
484.02, through 484.1, for polarization requires magneto rotation.
485.01, through 485.07, for polarization by reflection or refraction
486.01, through 486.03, for polarization direction or magnitude varied over surface of the medium.
487.01, through 487.06, for polarization by dichroism.
489.01, through 489.2, for polarization by birefringence.

601, through 614, for optical structure in general used to reduce unwanted light, not polarizing structure for reducing antiglare.

## SEE OR SEARCH CLASS:

40, Card, Picture, or Sign Exhibiting, particularly subclasses 434 and 548 for illuminated signs utilizing polarizers.
65, Glass Manufacturing, subclasses 30.1 and 32.1 for processes for forming polarizing glass material.

250, Radiant Energy, subclasses 225 and 559.09 for a light polarizer and a photocell and subclass 341.3 for invisible radiation energy response methods including polarization means.

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252. Compositions, subclass 585 for chemical compositions which produce polarized light.

264, Plastic and Nonmetallic Article Shaping or Treating: Processes, subclass 1.31 for light polarizing articles.
313, Electric Lamp and Discharge Devices, subclass 112 for electric lamps and electronic tubes combined with a polarizer.
343, Communications: Radio Wave Antennas, subclass 756 for antennas with a polarization converter and subclasses 909+ for radio wave polarizations, per se.

348, Television, subclasses 57 and 58 for stereoscopic displays with polarization.
349, Liquid Crystal Cells, Elements and Systems, subclass 9 for projectors with liquid crystal cell which produces $S$ and $P$ polarized light, subclass 80 for color polarizers in a liquid crystal cell, subclass 87 for variable polarizers in a liquid crystal cell, subclasses 96-103 for liquid crystal cell structure with polarizing element, and subclass 194 for liquid crystal polarizer.

351, Optics: Eye Examining, Vision Testing and Correcting, subclasses 49, 215, and 232 for light-polarizing devices used in eye examining vision testing and correcting means.

353, Optics: Image Projectors, subclasses 8 and 20 for polarizers used with image projectors.

355, Photocopying, subclass 71 for photocopy system having illumination system with a polarizer

356, Optics: Measuring and Testing, subclasses 30 and 31 for gem or crystal examining using polarized light; subclass 33 for material strain analysis with polarized light, subclasses 322 and 327 for spectrometers which utilize polarized light, subclasses 364-370 for polarized light examination devices generally, and subclasses 453, 487 and 491 for interferometers with polarizing elements.

362, Illumination, subclass 19 for illumination systems with a polarizing element.
365, Static Information Storage and Retrieval, subclasses 121 and 122 for polarization techniques used in the storage and retrieval of information.
369, Dynamic Information Storage or Retrieval, subclasses 13.29-13.31 for employing polarized light in a storage or retrieval device and subclasses 110.01110.04 and 112.16-112.21 for polarizing optical elements in an optical pick-up device.

372, Coherent Light Generators, subclass 106 for a polarizer in a coherent light generator (i.e., laser).
385, Optical Waveguides, subclass 11 for polarization devices without modulation and including an optical waveguide.

398, Optical Communications, subclass 65 for polarization in multiplexing optical communication devices, subclass 152 for transmitter/receiver systems that include polarization.

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427, Coating Processes, subclasses 163.1-163.4 for coating processes, per se, where the product is an optical element.

428, Stock Material or Miscellaneous Articles, subclass 1.31 for liquid crystal layers including polarizer.

472, Amusement Devices, subclasses 57-84 for a theatrical stage device which may use a polarizer.
501, Compositions: Ceramic, subclasses 30 and 56 for polarizers with specified glass compositions.

977, Nanotechnology, subclass 834 for nanomaterials having optical properties that may include polarization.
484.01 Polarization using a time invariant electric, magnetic, or electromagnetic field (e.g., electro-optical, magneto-optical):
This subclass is indented under subclass 483.01. Subject matter wherein an electric, magnetic, or electromagnetic field, which is unchanging in time, is applied to the optical device to produce or alter the polarization.

## SEE OR SEARCH CLASS:

356, Optics: Measuring and Testing, subclass 368 for polarimeters which include electro-optical light rotation.

365, Static Information Storage and Retrieval, subclasses 121 and 122 for information masking using magneto-optical polarization.
369, Dynamic Information Storage or Retrieval, subclasses 13.01 through 13.55 for magneto-optical storage systems.

385, Optical Waveguides, subclass 11 for polarization devices without modulation and including an optical waveguide.

### 484.02 Faraday effect:

This subclass is indented under subclass 484.01. Subject matter wherein the applied field is a magneto-optic field in which the magneto-optic field interacts with the optical device to produce a rotation in the plane of polarization (i.e., Faraday effect).
(1) Note. Included in this subclass are Faraday rotation devices without modulation. Faraday rotation devices that include modulation would be appropriate for subclasses 280-284.

## SEE OR SEARCH CLASS:

365, Static Information Storage and Retrieval, subclass 122 for information masking using magneto-optical polarization.
369, Dynamic Information Storage or Retrieval, subclasses 13.01 through 13.55 for magneto-optical storage systems.

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385, Optical Waveguides, subclass 11 for polarization devices without modulation and including an optical waveguide.

### 484.03 Isolator:

This subclass is indented under subclass 484.02. Subject matter wherein a Faraday effect element is used in an optical isolator.
(1) Note. An optical isolator is an optical device which allows the transmission of light in only one direction.

## SEE OR SEARCH CLASS:

372, Coherent Light Generators, subclass 703 for optical isolator in a coherent light generator (i.e., laser).

385, Optical Waveguides, subclass 11 for polarization devices without modulation and including an optical waveguide.

### 484.04 With reflector:

This subclass is indented under subclass 484.03. Subject matter wherein the optical isolator includes at least one reflective element (e.g., mirror, retroreflector, etc).

### 484.05 Circulator:

This subclass is indented under subclass 484.02. Subject matter wherein a Faraday effect element is used in an optical circulator.
(1) Note. An optical circulator is an at least three-port device that allows light to travel in only one direction (e.g., lights travels from port 1 to port 2, then from port 2 to port 3).

## SEE OR SEARCH CLASS:

385, Optical Waveguides, subclass 11 for polarization devices without modulation and including an optical waveguide.

398, Optical Communications, subclass 65 for polarization in multiplexing optical communication devices, subclass 152 for transmitter/receiver systems that include polarization, subclass 205 for heterodyne receiver including polarization.

### 484.06 Optical switch:

This subclass is indented under subclass 484.02. Subject matter wherein a Faraday effect element is used in an optical switch.
(1) Note. An optical switch is an optical device which enables light to be selectively switched from one port to another.

SEE OR SEARCH CLASS:

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385, Optical Waveguides, subclasses 16-23 for optical switches utilizing an optical waveguide.

398, Optical Communications, subclasses 45-57 for optical switching in multiplexing optical communication devices.
484.07 Interleaver:

This subclass is indented under subclass 484.02. Subject matter wherein a Faraday effect element is used in an optical interleaver.
(1) Note. An optical interleaver is an at least 3-port device that is used to combine two sets of wavelength-division multiplexing (WDM) channels (e.g., odd and even channels) into a composite signal stream in an interleaving way.

## SEE OR SEARCH CLASS:

385, Optical Waveguides, subclass 11 for polarization devices without modulation and including an optical waveguide.
398, Optical Communications, subclass 65 for polarization in multiplexing optical communication devices, subclass 152 for transmitter/receiver systems that include polarization, subclass 205 for heterodyne receiver including polarization.

### 484.08 Attenuator:

This subclass is indented under subclass 484.02. Subject matter wherein a Faraday effect element is used in an optical attenuator.
(1) Note. An optical attenuator is an optical device that reduces the amplitude or power of a signal.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

337.1, through 337.13, for spectral gain flattening or equalization.

## SEE OR SEARCH CLASS:

356, Optics: Measuring and Testing, subclass 370 for measuring/testing of polarized light having light attenuation.
385, Optical Waveguides, subclass 140 for optical attenuators including an optical waveguide.

### 484.09 Interference or comb filter:

This subclass is indented under subclass 484.02 . Subject matter wherein a Faraday effect element is used in an interference or comb filter.
(1) Note. An interference or comb filter is an optical filter that selectively reflects or transmits light in a narrow band of wavelengths.

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## SEE OR SEARCH THIS CLASS, SUBCLASS:

489.19, for frequency filters used for polarization by birefringence.

589, and 590, for general interference filters.

## SEE OR SEARCH CLASS:

353, Optics: Image Projectors, subclass 20 for polarizers used with image projectors.
356, Optics: Measuring and Testing, subclasses 491-495 for interferometers having polarization.

### 484.1 With particular Faraday effect material:

This subclass is indented under subclass 484.02. Subject matter wherein details of materials that are involved in the generation of the Faraday effect are recited.

## SEE OR SEARCH CLASS:

117, Single-Crystal, Oriented-Crystal, and Epitaxy Growth Processes; Non-Coating Apparatus Therefor, subclass 54 for the process of growing magnetic compositions.

252, Compositions, subclass 585 for chemical compositions which produce polarized light and subclasses 62.51+ for the magnet material composition.

335, Electricity: Magnetically Operated Switches, Magnets, and Electromagnets, subclasses 209-306 for the magnet structure.
485.01 Polarization by reflection or refraction:

This subclass is indented under subclass 483.01 . Subject matter wherein a light beam is polarized as a result of either (1) by striking a surface and returning into the originating medium of an optical element or (2) by redirecting as it passes through media of differing indices of refraction of the optical element.
(1) Note. The reflection or refraction phenomena must follow Snell's Law to be appropriate for this subclass.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclass 9 for projectors with liquid crystal cell which produces $S$ and $P$ polarized light, subclasses 96-103 for liquid crystal cell structure with polarizing element and subclass 194 for liquid crystal polarizer.

353, Optics: Image Projectors, subclass 20 for polarizers used with image projectors.
362, Illumination, subclass 19 for illumination systems with a polarizing element.
485.02 Brewster angle polarizer (reflective or transmissive):

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This subclass is indented under subclass 485.01. Subject matter wherein the polarizing optical element reflects or transmits light at Brewster's angle.
(1) Note. Since the reflection coefficient for light which has an electric field parallel to the plane of incidence goes to zero at some incidence angle between $0^{\circ}$ and $90^{\circ}$, the reflected light at that angle (Brewster's angle) is linearly polarized with its electric field vectors perpendicular to the plane of incidence and parallel to the plane of the surface from which it is reflecting.

## SEE OR SEARCH CLASS:

372, Coherent Light Generators, subclass 106 for a polarizer in a coherent light generator (i.e., laser).

### 485.03 Multilayer polarizer:

This subclass is indented under subclass 485.01. Subject matter wherein the polarizing optical element includes a plurality of layers, at least one of which is reflective or refractive.
(1) Note. Multilayer optical elements which operate using optical interference are appropriate for this subclass.
(2) Note. Multilayer optical elements that include one or more birefringent layers should be classified in 489.19 and are not appropriate for this subclass.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

371, for interference microscopes which may utilize polarized light.
580, through 590, for general optical inference elements.

### 485.04 Pile-of-plates polarizer:

This subclass is indented under subclass 485.03 . Subject matter wherein a polarization is reflected or transmitted from a stack of plates (e.g., dielectric plates).

### 485.05 Wire grid polarizer:

This subclass is indented under subclass 485.01 . Subject matter wherein the polarizing optical element includes metallic conductors in the form of a reflective grid (i.e., each grid opening forms a half wavelength of the applied light) to produce a polarization of the applied light.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

352, for a polarizing element having significant infrared or ultraviolet properties.
569, through 576, for diffractive optical elements.

SEE OR SEARCH CLASS:

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216, Etching a substrate: Processes, subclass 24 for general etching processes

### 485.06 Prism:

This subclass is indented under subclass 485.01 . Subject matter wherein the polarizing optical element has at least two plane surfaces inclined relative to each other, from which light is reflected or through which light is refracted.
(1) Note. A prism may be employed for refracting or reflecting light. Prism reflections are considered to be internal reflections; that is, the light is inside the prism body both before and immediately after the reflection.
(2) Note. The prismatic element may include a plurality or an array of prisms (e.g., crossed prisms, x-prisms or kernel prisms).

## SEE OR SEARCH THIS CLASS, SUBCLASS:

489.09, and 489.1, for prisms used for polarization by birefringence.

629, through 638, for general beam splitting elements.
831, through 837, for prisms, per se.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclasses 8-9 for projectors with liquid crystal cell which produces $S$ and $P$ polarized light.
353, Optics: Image Projectors, subclass 20 for polarizers used with image projectors.
485.07 Mirror:

This subclass is indented under subclass 485.01 . Subject matter wherein the reflective element is a mirror.
(1) Note. The reflective element may include a plurality or an array of mirrors.
486.01 Polarization (direction or magnitude) variation over surface of the medium:

This subclass is indented under subclass 483.01 . Subject matter comprising a surface which transmits or reflects light and whose ability to polarize light is not uniform across the surface.
(1) Note. This variation in polarizing ability may be continuous or discontinuous and may form any type of pattern. For example, the different areas of a surface may form an image or design as in a "vectograph".

### 486.02 Linear variation:

This subclass is indented under subclass 486.01. Subject matter wherein the polarization varies along a single direction or two orthogonal directions (e.g., matrix or checkerboard).

| P1 | P2 | P1 | P2 | P1 |
| :--- | :--- | :--- | :--- | :--- |
|  |  |  |  |  |
|  |  |  |  |  |
|  |  |  |  |  |

A typical example of the subject matter.

| P1 |  |  |  |  |
| :--- | :--- | :--- | :--- | :--- |
| P2 |  |  |  |  |
| P1 |  |  |  |  |
| P2 |  |  |  |  |

A typical example of the subject matter.


A typical example of the subject matter.

### 486.03 Radial variation:

This subclass is indented under subclass 486.01 . Subject matter wherein the polarization varies around an optical axis.


A typical example of the subject matter.

### 487.01 Polarization by dichroism:

This subclass is indented under subclass 483.01. Subject matter including an optical element made of dichroic materials which have different absorption for different incident polarization planes of light.
(1) Note. Included here are elements where the medium comprises a lamination or a coating on a supporting structure and where the supporting structure is significant or the means to form the lamination or coating is significant.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

352, for a polarizing element having significant infrared or ultraviolet properties.
580, for general dichroic elements without polarization properties.

## SEE OR SEARCH CLASS:

156, Adhesive Bonding and Miscellaneous Chemical Manufacture, subclasses 99-108 for processes of adhesively bonding laminae.
252. Compositions, subclass 585 for chemical compositions which produce polarized light.
427, Coating Processes, subclasses 163.1-163.4 for coating processes, per se, where the product is an optical element.

### 487.02 With stain or dye:

This subclass is indented under subclass 487.01. Subject matter wherein the polarizing optical element is made of dichroic coloring agent, such as a dye or stain (e.g., Polaroid H or K sheets or dichroic iodine-based films).

## SEE OR SEARCH CLASS:

428, $\quad$ Stock material or miscellaneous articles, subclass 1.31 for liquid crystal layers including polarizer.

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### 487.03 Wire grid polarizer:

This subclass is indented under subclass 487.01 . Subject matter wherein the polarizing optical element includes metallic conductors in the form of an absorptive grid (i.e., each grid opening forms a half wavelength of the applied light) to produce polarization of the applied light.

SEE OR SEARCH THIS CLASS, SUBCLASS:
569, through 576, for diffractive optical elements.

## SEE OR SEARCH CLASS:

216, Etching a substrate: Processes, subclass 24 for general etching processes

### 487.04 Wavelength-selective beamsplitter:

This subclass is indented under subclass 487.01 . Subject matter wherein the polarizing dichroic optical element is used to selectively separate or split the light beam into components of different wavelengths.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

634, for wavelength-selective, dichroic reflectors.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclasses 8-9 for projectors with liquid crystal cell which produces $S$ and $P$ polarized light.

353, Optics: Image Projectors, subclass 20 for polarizers used with image projectors.

### 487.05 Having plural elements:

This subclass is indented under subclass 487.01 . Subject matter wherein the polarizing optical device includes a plurality of dichroic elements.
(1) Note. The plurality of dichroic elements may include a plurality of layers, films, coatings or optical devices.

### 487.06 Oriented particles:

This subclass is indented under subclass 487.01. Subject matter wherein the polarization of the applied light is dependent upon the spatial positioning of microscopic particles embedded in the dichroic medium of the polarizing optical element.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

487.01, for polarization caused by the molecular orientation of the matrix material or of a reaction product.
487.02, for stain or dye molecules acting as oriented particles.

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### 488.01 Glare prevention by discriminating against polarized light:

This subclass is indented under subclass 483.01 . Subject matter wherein unwanted glareproducing polarized light is eliminated by a polarizing structure.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

490.01, through 490.03, for two superimposed relatively adjustable polarizers mounted as a unit and used to reduce or control light intensity.

601, through 614, for glare reduction not utilizing a polarizer.

### 489.01 Polarization by birefringence:

This subclass is indented under subclass 483.01 . Subject matter wherein the polarizing optical element includes crystalline materials having two distinct indices of refraction associated with different crystallographic directions, i.e. birefringent materials.
(1) Note. A birefringent element has the property of dividing a ray or beam of energy into two polarized rays or beams (known as the ordinary and extraordinary rays), the directions of polarization being at right angles to each other.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

489.09, for a birefringent element in the form of a Nicol prism where the unwanted ray is deflected.

## SEE OR SEARCH CLASS:

65, Glass Manufacturing, subclasses 30.1 and 32.1 for processes for forming polarizing glass material.

356, Optics: Measuring and Testing, subclass 365 for measuring/testing of polarized light having a birefringent element.
501, Compositions: ceramic, subclasses 30 and 56 for polarizers with specified glass compositions.
489.02 With compensation techniques:

This subclass is indented under subclass 489.01. Subject matter wherein the birefringent element corrects for unwanted effects.

SEE OR SEARCH CLASS:
349, Liquid Crystal Cells, Elements and Systems, subclasses 117-121 for liquid crystal cell including compensation.
489.03 Intrinsic birefringence or photoelastic (stress) effect:

This subclass is indented under subclass 489.02. Subject matter wherein the unwanted effect is intrinsic birefringence or photoelastic (stress) effect.

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## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclass 120 for liquid crystal cell including compensation for negative intrinsic birefringence (i.e., negative refractive index anisotropy).
489.04 Temperature:

This subclass is indented under subclass 489.02. Subject matter wherein the unwanted effect is temperature.

### 489.05 Path length:

This subclass is indented under subclass 489.02. Subject matter wherein the unwanted effect is changes in optical or physical path length.
(1) Note. Included in this subclass are optical delay lines.

### 489.06 Form birefringent element:

This subclass is indented under subclass 489.01. Subject matter wherein the optical element exhibits different refractive indices as a result of an anisotropic physical structure on a scale much larger than molecular but much smaller than the wavelength of light.
(1) Note. Examples of such elements may include polarizing dielectric diffraction gratings or polarizing lattice grids.
(2) Note. Form birefringence is also known as structural birefringence or structureinduced birefringence.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

566, through 576, for diffractive optical elements.

## SEE OR SEARCH CLASS:

369, Dynamic Information Storage or Retrieval, subclasses 112.03-112.15 for optical pick-up devices having a diffractive element.

### 489.07 Waveplate or retarder:

This subclass is indented under subclass 489.01. Subject matter wherein the birefringent element is used to alter the polarization state of a light wave traveling through it by shifting the phase between the two perpendicular polarization components of the incident light beam, i.e., birefringent waveplate or retarder.
(1) Note. Included in this subclass are waveplates or retarders that are EXPLICITLY birefringent, i.e. the waveplate or retarder is birefringent, anisotropic, uniaxial, biaxial or double (doubly) refractive; the waveplate or retarder is made from a birefringent crystalline material such as quartz, calcite,

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tourmaline, rutile, sodium nitrate, magnesium fluoride, sapphire, etc.; or the waveplate or retarder has been specified to have two distinct indices of refraction associated with different crystallographic directions, such as those producing ordinary and extraordinary rays.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclass 18 for projectors with liquid crystal cell that includes a variable or rotatable retarder and subclasses 117-118 for specific liquid crystal cell structures with birefringent retarders.

### 489.08 Beam deflector or splitter:

This subclass is indented under subclass 489.01. Subject matter wherein the birefringent element is used to change the direction of the entire beam or a portion of the beam for positioning purposes or is used to split the beam into two or more portions.
(1) Note. The polarization splitter may include a plurality or an array of splitters.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

485.01, through 485.07, and 487.04, for polarized beam deflection and splitting using nonbirefringent medium.
489.09, for prism structures which could be used for beam splitting.

629, through 638, for general beam splitting elements.
489.09 Prism:

This subclass is indented under subclass 489.08 . Subject matter wherein the birefringent element has at least two plane surfaces inclined relative to each other, from which light is reflected or through which light is refracted.
(1) Note. A prism may be employed for refracting or reflecting light. Prism reflections are considered to be internal reflections; that is, the light is inside the prism body both before and immediately after the reflection.
(2) Note. The prismatic element may include a plurality or an array of prisms (e.g., crossed prisms, x-prisms or kernel prisms).
(3) Note. The prismatic element may also be doubly refractive, wherein light incident on the prismatic element undergoes decomposition into two rays, the ordinary ray and the extraordinary ray (e.g., Glan prism, Wollaston prism, Rochon prism, Sernarmont prism, Nicol prism, Feussner polarizer, etc.). This phenomena occurs when the optic axis of the element is at an arbitrary angle with respect to the incident beam direction (i.e., not parallel).

## SEE OR SEARCH THIS CLASS, SUBCLASS:

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485.06, for prisms used for polarization by reflection or refraction.

639, and 640, for refraction at the beam splitting or combining surface of a prismatic element.

831, through 837, for prisms, per se.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclasses 8-9 for projectors with liquid crystal cell which produces $S$ and $P$ polarized light.

353, Optics: Image Projectors, subclass 20 for polarizers used with image projectors.

### 489.1 Adjustable element(s):

This subclass is indented under subclass 489.09. Subject matter wherein the prismatic element is movable to adjust the optical characteristics of the prismatic element (e.g., Soleil-Babinet compensators).

### 489.11 Film or layer:

This subclass is indented under subclass 489.08. Subject matter wherein the polarization splitter includes at least one thin film, layer, or coating of birefringent materials.

## SEE OR SEARCH CLASS:

427, Coating Processes, subclasses 163.1-163.4 for coating processes, per se, where the product is an optical element.
489.12 Uniaxial:

This subclass is indented under subclass 489.11. Subject matter including birefringent materials wherein the refractive indices of two of the three orthogonal directions are the same.
(1) Note. Included in this subclass are both positive and negative birefringent uniaxial materials.

### 489.13 Biaxial:

This subclass is indented under subclass 489.11. Subject matter including birefringent materials wherein the refractive indices of all three orthogonal directions are different.

### 489.14 Lens:

This subclass is indented under subclass 489.01. Subject matter wherein the birefringent element is a lens.
(1) Note. A birefringent lens is defined as either a single transparent mass of birefringent refractive material having opposed refracting surfaces or a plurality of such masses arranged along an optical axis with their opposed refracting surfaces disposed transversely of such axis.

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## SEE OR SEARCH THIS CLASS, SUBCLASS:

489.18, for optical systems with lenses and plural birefringent elements.

### 489.15 Plural birefringent elements:

This subclass is indented under subclass 489.01. Subject matter wherein beam polarization is achieved by multiple birefringent elements.

SEE OR SEARCH THIS CLASS, SUBCLASS:
371, and 386, for microscopes using polarized light which may utilize birefringent elements.

465, for stereoscopic systems with polarizing elements which may be birefringent.
489.09, through 489.1, for prism structures made up of plural elements.
486.01, for elements where the polarization varies over surface of the medium.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclasses 8-9 for projectors with liquid crystal cell which produces $S$ and $P$ polarized light.
353, Optics: Image Projectors, subclass 20 for polarizers used with image projectors.
362, Illumination, subclass 19 for illumination systems with polarizing elements.

### 489.16 Three or more birefringent elements:

This subclass is indented under subclass 489.15. Subject matter wherein beam polarization is achieved by at least three birefringent elements.

### 489.17 In parallel:

This subclass is indented under subclass 489.15. Subject matter wherein the birefringent elements are arranged transverse to the light propagation direction, i.e., positioned in parallel.
489.18 With lenses:

This subclass is indented under subclass 489.15. Subject matter wherein the optical system also includes a plurality of lenses in series or in a lens array.
(1) Note. Included in this subclass are optical systems with plural birefringent elements including lens (or lenses) that are NOT birefringent.

### 489.19 Frequency filter or interference effects:

This subclass is indented under subclass 489.15. Subject matter wherein plural elements act to pass a particular frequency or band of frequencies, or wherein interference effects are used to produce effects such as color or an interference pattern.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

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370, and 371, for interference microscopes which may utilize birefringent elements.
487.01, for color effects using dichroic medium.

580, through 590, for general optical inference elements.
634, for wavelength selective beam splitting systems.
885, through 892, for an absorption filter.

### 489.2 Mounting structure:

This subclass is indented under subclass 489.01. Subject matter wherein detailed structures for mounting the birefringent element are recited.

SEE OR SEARCH THIS CLASS, SUBCLASS:
819, through 830, for generic lens mounts.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclasses 58-60 for generic mounting structures to hold liquid crystal cells.
490.01 By relatively adjustable superimposed or in series polarizers:

This subclass is indented under subclass 483.01. Subject matter wherein the polarizers are positioned one on top of another or arranged in a row and their positions are adjustable.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

489.2, for mounting structure of superimposed birefringent elements.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclass 18 for projectors with liquid crystal cell that includes a variable or rotatable retarder.

### 490.02 Rotating elements:

This subclass is indented under subclass 490.01. Subject matter wherein the elements are adjustable by rotation.

### 490.03 Translating or sliding elements:

This subclass is indented under subclass 490.01. Subject matter wherein the elements are adjustable by translation or sliding.

### 491.01 With color filter:

This subclass is indented under subclass 483.01. Subject matter where a polarizing structure is combined with structure to selectively absorb or transmit specific light wavelengths.

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## SEE OR SEARCH THIS CLASS, SUBCLASS:

485.03, for similar subject matter where the only color produced is a result of interference.
487.01, through 487.06, for similar subject matter where the color is produced by a dichroic medium. (See (1) Note under subclass 487.01 for the definition of dichroic.)
489.19, for similar subject matter where the only color produced is a result of interference between the ordinary and extraordinary light rays.

## SEE OR SEARCH CLASS:

349, Liquid Crystal Cells, Elements and Systems, subclasses 80 and 97 for liquid crystal cell structure with color filter.

### 492.01 Polarization by optical activity:

This subclass is indented under subclass 483.01. Subject matter wherein the material of the optical element naturally rotates the plane of polarization of the incident light beam without the application of any external applied fields (e.g., electrical, magnetic, stress or pressure).

## SEE OR SEARCH CLASS:

252, Compositions, subclass 585 for chemical compositions which produce polarized light.
493.01 Polarization by scattering:

This subclass is indented under subclass 483.01. Subject matter wherein a light beam is polarized as a result of scattering or diffusing from an optical medium.
(1) Note. The scattering or diffusing phenomena must NOT follow Snell’s Law to be appropriate for this subclass.

## SEE OR SEARCH THIS CLASS, SUBCLASS:

599, for general optical elements that diffuse incident light.

### 494.01 Depolarization:

This subclass is indented under subclass 483.01. Subject matter wherein the optical element converts an incident polarized light beam to produce an unpolarized, depolarized or randomly polarized output light beam.

FOR 131 POLARIZATION WITHOUT MODULATION (359/483):
This foreign art collection is indented under the class definition. Foreign art collection wherein the polarization of an incoming light beam is modified in a time invariant fashion as a result of passing through some optical device.

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(1) Note. Where both a polarizing device and a composition are claimed, the patent is classified here and cross-referenced to Class 252, subclass 585.
(2) Note. Where a method of making the polarizing device is claimed as well as the polarizing device, the patent is classified here and cross-referenced to any other class providing for the method.
(3) Note. The nominal recitation of a polarizing area in the form of a design, image, etc., is sufficient to include this subject matter in this subclass.

FOR 132 Time invariant electric, magnetic or electromagnetic field responsive (e.g., electrooptical, magneto-optical) (359/484):
This foreign art collection is indented under FOR 131. Foreign art collection wherein an electrical, magnetic, or electromagnetic field, which is unchanging in time, is applied to the device producing the polarization.
(1) Note. This would include optical isolators and circulators.

## FOR 133 Light polarization without any external input (359/485):

This foreign art collection is indented under FOR 131. Foreign art collection wherein an optical device causes optical energy to vibrate in accordance with a regular pattern that differs from the input without the application of any supplemental energy.

FOR 134 By grid or dipoles (359/486):
This foreign art collection is indented under FOR 133. Foreign art collection wherein electrical conductors in the form of a grid (i.e., each grid opening forms a half wavelength of the applied light) or half wavelength dipoles embedded in the medium produce polarization of the applied light.

FOR 135 By reflection or refraction (e.g., Brewster angle) (359/487):
This foreign art collection is indented under FOR 133. Foreign art collection wherein a light beam is polarized as a result of either (1) striking a surface and returning into the originating medium or (2) redirection as it passes through media of differing optical densities.

## FOR 136 With particular medium (359/488):

This foreign art collection is indented under FOR 135. Foreign art collection wherein details of the reflecting or refracting medium are recited (e.g., physical composition, structure, specific indexes of refraction, or thickness of layers).
(1) Note. Physical shape (other than layered mediums) or arrangement of elements or mediums is not considered a particular medium for this subclass.

FOR 137 Polarization (direction or magnitude) varies over surface of the medium (e.g., vectograph) (359/489):
This foreign art collection is indented under FOR 133. Foreign art collection comprising a surface which transmits or reflects light and whose ability to polarize light is not uniform across the surface.

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(1) Note. This variation in polarizing ability may be continuous or discontinuous and may form any type of pattern. For example, the different areas of a surface may form an image or design as in a "vectograph".

## FOR 138 By dichroic medium (359/490):

This foreign art collection is indented under FOR 133. Foreign art collection including an optical element which effects the degree of polarization dependent upon the relative absorption therein of the two components or vectors of light.
(1) Note. A dichroic element will transmit light of one color and reflect light of the complementary color with little light being absorbed. These elements are composed of superimposed strata of dielectric material, which are classified in subclass 580.
(2) Note. Included here are elements where the medium comprises a lamination or a coating on a supporting structure and where the supporting structure is significant or the means to form the lamination or coating is significant.

FOR 139 Stain or dye (359/491):
This foreign art collection is indented under FOR 138. Foreign art collection wherein a coloring agent is absorbed by the polarization medium to affect the polarization of the applied light beam.

## FOR 140 Oriented particles (359/492):

This foreign art collection is indented under FOR 138. Foreign art collection wherein the polarization of the applied light is dependent upon the spatial positioning of microscopic particles embedded in the dichroic medium.

## FOR 141 Glare prevention by discriminating against polarized light (359/493):

This foreign art collection is indented under FOR 133. Foreign art collection wherein unwanted glare-producing light, having a particular polarization, is eliminated by a polarizing structure.

## FOR 142 By birefringent element (359/494):

This foreign art collection is indented under FOR 133. Foreign art collection including an element having the property of dividing a ray or beam of energy into two polarized rays or beams (known as the ordinary and extraordinary rays), the directions of polarization being at right angles to each other.
(1) Note. A birefringent material which has been treated with a dichroic dye to absorb the ordinary or extraordinary ray is no longer considered to be birefringent within the meaning of this definition. A birefringent element in the form of a Nicol prism where the unwanted ray is deflected is classified here.

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This foreign art collection is indented under FOR 142. Foreign art collection wherein the entire beam or a portion of the beam is caused to change direction for positioning purpose or wherein the beam is split into two or more portions.

## FOR 144 Prisms (359/496):

This foreign art collection is indented under FOR 142. Foreign art collection wherein the birefringent element is formed into a structure bound in part by two plane faces that are not parallel and combinations of the structure.

FOR 145 Using plural elements (359/497):
This foreign art collection is indented under FOR 142. Foreign art collection wherein beam polarization is achieved by multiple birefringent elements.

FOR 146 Frequency filter or interference effects (359/498):
This foreign art collection is indented under FOR 145. Foreign art collection wherein plural elements act to pass a particular frequency or band of frequencies, or wherein interference effects are used to produce effects such as color or an interference pattern.

## FOR 147 Using compensation techniques 359/499):

This foreign art collection is indented under FOR 145. Foreign art collection wherein at least one of the elements corrects for unwanted effects, such as those due to temperature.

## FOR 148 With particular material or mounting structure (359/500):

This foreign art collection is indented under FOR 142. Foreign art collection wherein details of the birefringent material, such as the type, size, shape, crystal cut, or treatment thereof or detailed structures for mounting the material are recited.

FOR 149 By relatively adjustable superimposed or in series polarizers (359/501):
This foreign art collection is indented under FOR 133. Foreign art collection wherein the polarizers are positioned one on top of another or arranged in a row and their positions are adjustable.

FOR 150 With color filter (359/502):
This foreign art collection is indented under FOR 133. Foreign art collection where a polarizing structure is combined with structure to selectively absorb or transmit specific light wavelengths.

## D. CHANGES TO THE DEFINITIONS

## CLASS 360 - DYNAMIC MAGNETIC INFORMATION STORAGE OR RETRIEVAL

Definitions Modified:

Class Definition: Under SECTION IV, REFERENCES TO OTHER CLASSES, SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 281+ and 484.01 through 484.1, magneto-optical polarization devices usable in magnetic signal reproduction.

## D. CHANGES TO THE DEFINITIONS

## CLASS 362 - ILLUMINATION

Definitions Modified:

Class Definition: Under SECTION IV, REFERENCES TO OTHER CLASSES, SEE OR SEARCH CLASS

Delete:

The first occurring reference to Class 359

Insert:

359, Optical: Systems and Elements, subclass 885 for optical filters, and subclasses 484.01 through 494.01 for polarizers. (See Lines With Other Classes, "Special Applications.")

Subclass 19: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 484.01 through 494.01 for (a) light polarizing compositions, (b) light polarizing devices, and (c) polarizing systems not provided for in some other optical class.

Definitions Modified:

Class Definition: Under SECTION IV, REFERENCES TO OTHER CLASSES, SEE OR SEARCH CLASS

## Delete:

The first occuring reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 350+ for infrared and ultraviolet optical elements, subclasses 1+ for holographic records, subclasses 484.01 through 494.01 for polarization devices, and subclasses 290+ for light control by altering an optical medium, surface, or interface (See Lines With Other Classes, F.)

Subclass 10: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 281+ and subclasses 484.01 through 484.1 where the properties of the polarized light beam are changed as a result of a magnetic field.

Subclass 65: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

## D. CHANGES TO THE DEFINITIONS

359, Optical: Systems and Elements, subclasses 245+ for light control with ferroelectric devices and subclasses 484.01 through 484.1for polarization using ferroelectric devices.

## Subclass 117:

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 245+ for light control with ferroelectric devices and subclasses 484.01 through 484.1for polarization using ferroelectric devices.

Subclass 121: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 240+ and subclasses 484.01 through 484.1 for changing the properties of polarized light by an applied field.

Subclass 145: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses $245+$ for light control with
ferroelectric devices and subclasses 484.01 through 484.1 for polarization using
ferroelectric devices.

## D. CHANGES TO THE DEFINITIONS

## CLASS 369 - DYNAMIC INFORMATION STORAGE OR RETRIEVAL

Definitions Modified:

## Subclass 110.01: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarized or polarizing optical elements, per se.

Subclass 112.16: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for polarized or polarizing optical elements, per se.

Subclass 275.2: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 280+ and subclasses 484.01 through 484.1 for magneto-optical polarization.

## D. CHANGES TO THE DEFINITIONS

## CLASS 385 - OPTICAL WAVEGUIDES

Definitions Modified:

Subclass 11: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01 through 494.01 for light polarization without modulation outside of a waveguide.

## D. CHANGES TO THE DEFINITIONS

CLASS 386 - MOTION VIDEO SIGNAL PROCESSING FOR RECORDING OR REPRODUCING

Definitions Modified:

Class Definition: Under SECTION II, REFERENCES TO OTHER CLASSES, SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 281+ and subclasses 484.01 through 484.1 for magneto-optical polarization devices usable in magnetic signal reproduction.

## D. CHANGES TO THE DEFINITIONS

## CLASS 396 - PHOTOGRAPHY

Definitions Modified:

Subclass 305: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclass 491.01 for polarization elements with color filters, subclasses 618+ for light dividing, combining or plural image forming and subclasses 885+ for absorption filters, per se.

## D. CHANGES TO THE DEFINITIONS

## CLASS 398 - OPTICAL COMMUNICATIONS

Definitions Modified:

## Subclass 65: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclass 246 for electro-optical modulation of polarized light, subclass 281 for magneto-optical modulation of polarized light, subclass 301 for light wave directional modulation acting on polarized light, and subclasses 483.01 through 494.01 for polarization without modulation.

Subclass 205: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 246 through 258 for electro-optic modulation of polarized light, subclasses 281 through 283 for magneto-optic modulation of polarized light, subclasses 301 through 304 for light wave directional modulation acting on polarized light, and subclasses 483.01 through 494.01 for polarization without modulation.

## D. CHANGES TO THE DEFINITIONS

## CLASS 427 - COATING PROCESSES

Definitions Modified:

## Subclass 163.1: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01-494.01 for polarization, per se.

## D. CHANGES TO THE DEFINITIONS

## CLASS 428 - STOCK MATERIAL OR MISCELLANEOUS ARTICLES

Definitions Modified:

Subclass 438: In the (2) Note

Delete:

483+

Insert:
483.01 through 494.01

Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01-494.01 for a laminated polarizer and subclasses 885+ for optical filters. See (2) Note above.

Subclass 910: Under SEE OR SEARCH CLASS

Delete:

The reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 483.01-494.01 for an optical system (e.g., filters, etc.) in which the molecules are oriented for an optical purpose (e.g., polarization, etc.).

## D. CHANGES TO THE DEFINITIONS

CLASS 430 - RADIATION IMAGERY CHEMISTRY: PROCESS, COMPOSITION, OR PRODUCT THEREOF

Definitions Modified:

Class Definition: Under SECTION III, REFERENCES TO OTHER CLASSES, SEE OR SEARCH CLASS

## Delete:

The first occuring reference to Class 359

Insert:

359, Optical: Systems and Elements, subclasses 478+ for relief illusion device; subclasses 885+ for nonchemically defined filter; subclass 893 for screen or mask; subclasses 36+ for elements using liquid crystal material; subclasses 1+ for holographic element; and subclasses 483.01-494.01 for polarizers. (See Lines With Other Classes, "Lines With And Search Notes To Articles or Product Classes" above).

